



Recent Advances in Engineered Surfaces, Nanostructured Coatings & Novel Deposition Techniques

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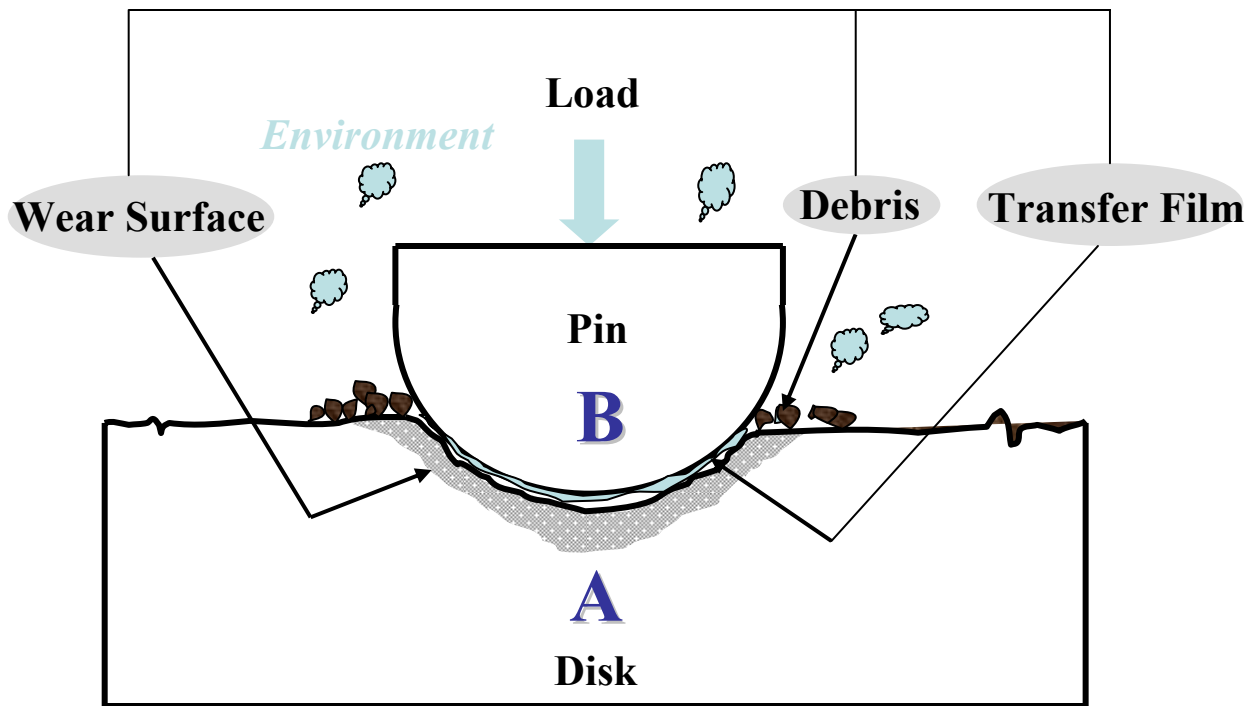
(svprasa@sandia.gov)

Next Generation Materials for Defense 2007

Institute for Defense and Government Advancement

March 29, 2007, Arlington, VA

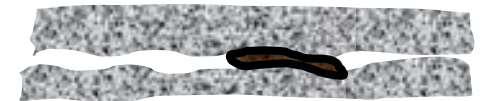
Tribology is a systems property



**Mechanical Interlocking
(Surface Morphology)**



Adhesion



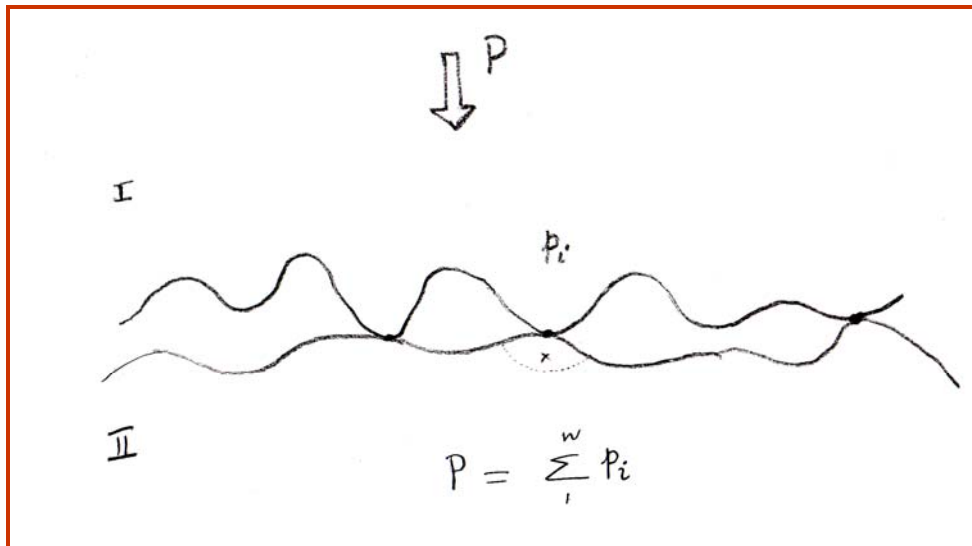
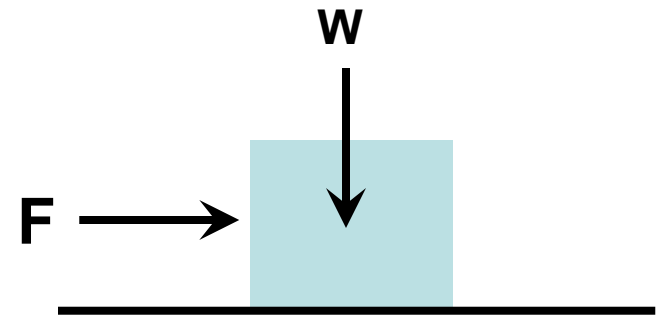
Debris Entrapment

Recognize the limitations of the laws of friction

Guillaume Amontons (1663-1705)

Unaware of da Vinci's (1452-1519) recorded observations

- Friction force is proportional to normal force
- Magnitude of friction force does not depend on the apparent area of contact



- Engineering surfaces are not atomically flat
- Contact will be at asperity level
- Surface composition typically differs from the bulk
- Sliding contact results:
 - Plastic deformation
 - Diffusion
 - Fracture initiation
 - Tribochemistry and Environmental reactions



Tribomaterials

Major Examples

- Materials for Bearings
- Friction Materials
- Abrasion-Resistant Materials
- Metal-Cutting Tools
- Biomedical Materials

Friction and Wear

Materials for Tribological Applications must also have a
“*Precise Balance of Physical and Mechanical Properties*”

(thermal expansion, damping capacity, conformability, strength, stiffness and fatigue life)

It is practically impossible to meet these diverse requirements with single phase materials. Materials strategies include:

- Composite Materials
- Engineered Surfaces
- Coatings

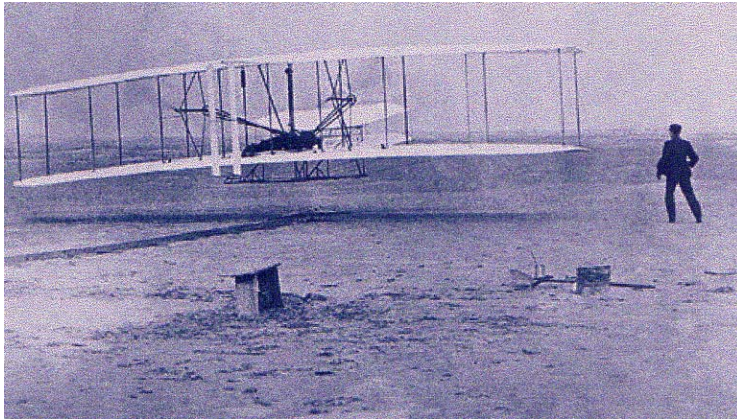


Outline

- Historic Example
 - Development of Wright Brothers' Engine
- Materials by Design
 - Metal-Matrix Composites (MMCs)
 - Polymer-Derived Ceramics (PDCs)
- Solid Lubricants, Thin Films and Coatings
 - Transition metal dichalcogenides (MoS_2 , WS_2)
 - Diamond-Like Carbon
- Tribological Issues in MEMS
- Atomic Layer Deposition

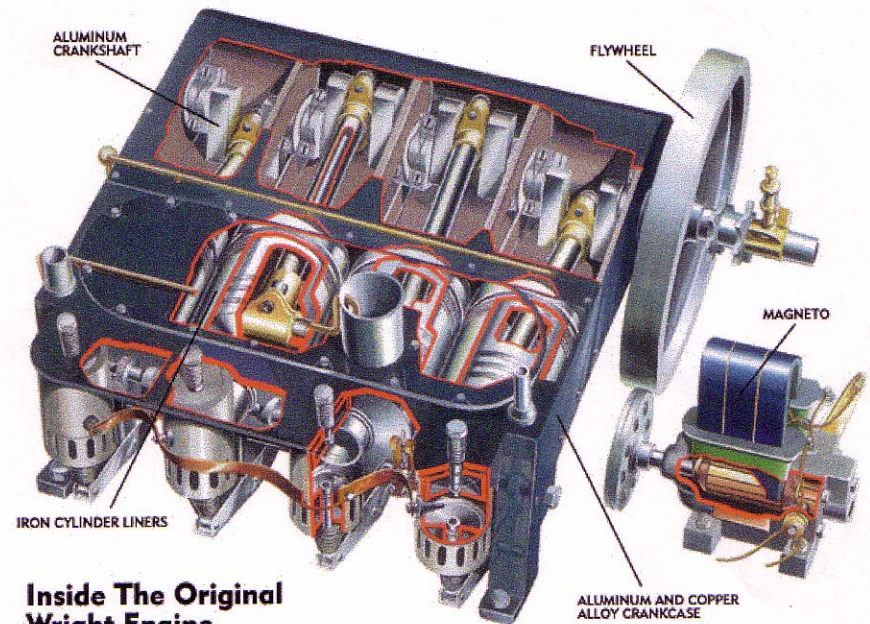
Historical Perspective: The Saga of Wright Brothers' Engine Development

1903



Mr. Charles Taylor (Mechanic)
Considered replacing CI with Al-Cu

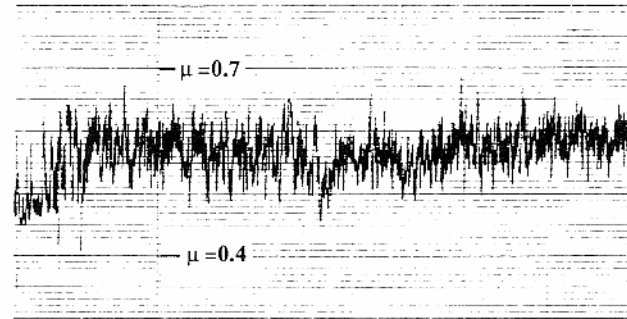
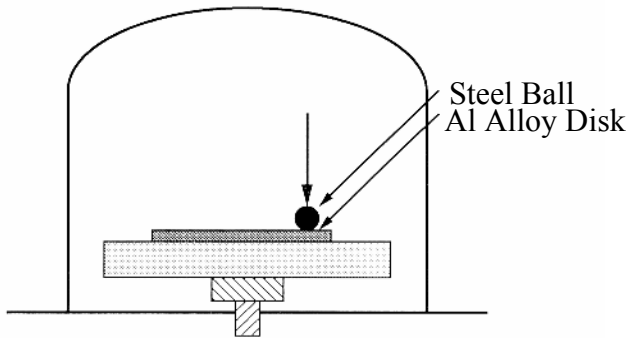
- The Brothers needed an Engine with 8 HP weighing <180 lbs



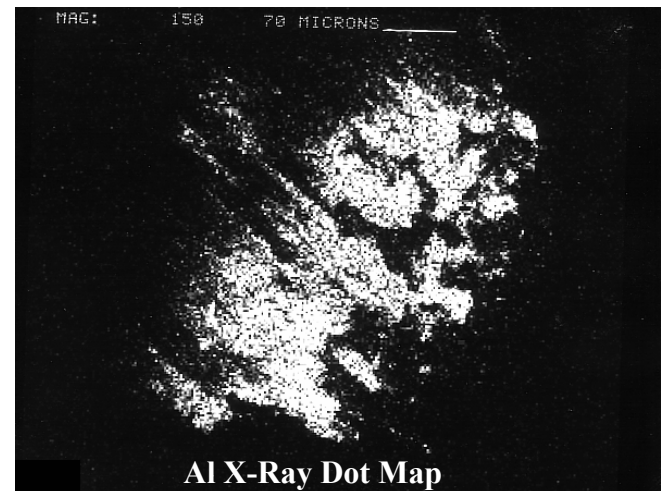
Inside The Original Wright Engine

- 16 HP-12HP 178 lbs
- The Brothers used the extra weight allowance to strengthen the wings and frame
- But Al has a tendency for seizure and galling in the absence of complete fluid film lubrication

Aluminum has poor resistance to seizure and galling

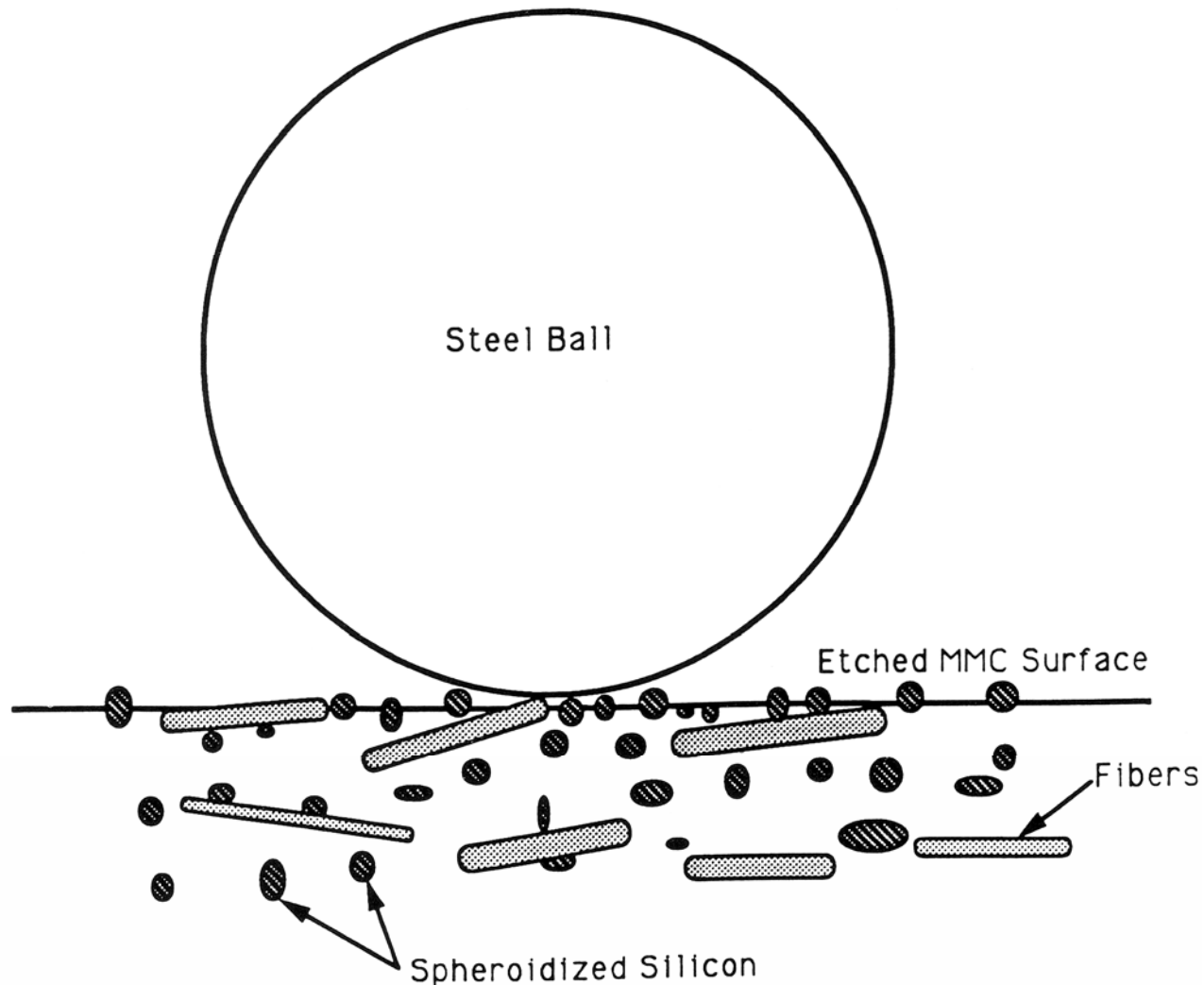


- In the absence of external fluid lubrication, aluminum has a tendency to adhere to the hard counterface, creating an interface of weak nature. Note the transfer of aluminum to the steel counterface during a ball-on-disk test. Friction is of stick-slip type with a coefficient of 0.5 to 0.6.



Mr Taylor's solution: Use thin cast iron liners in Al-Cu crankcase

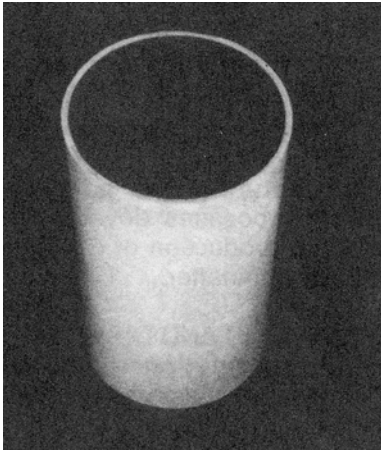
Engineered Surfaces for Precise Balance of Tribological and Physical Properties



S. V. Prasad and K. R. Mecklenburg, *Wear* 162 (1993) 47-56

IDGA_Prasad:8

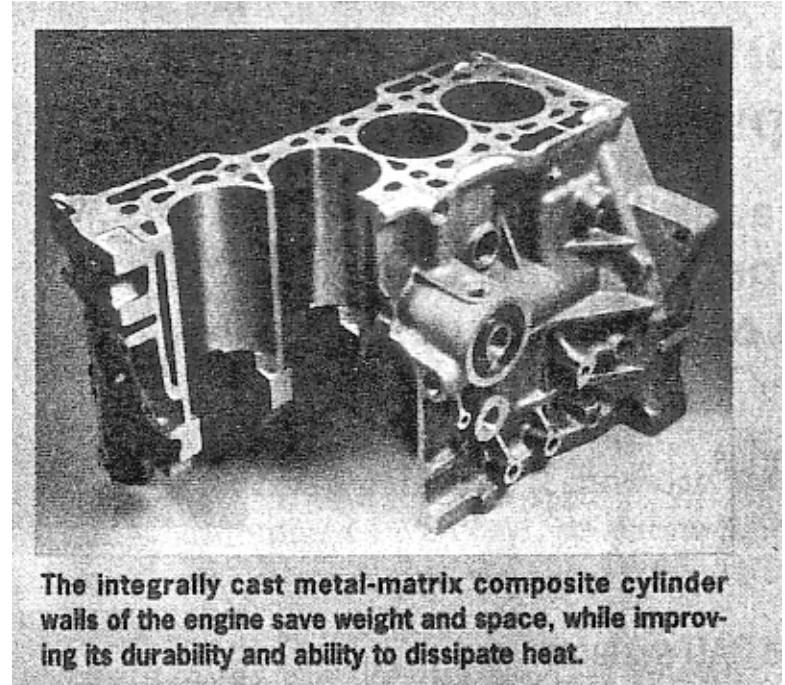
Integrally Cast MMC Cylinder: Honda Corporation



Preform

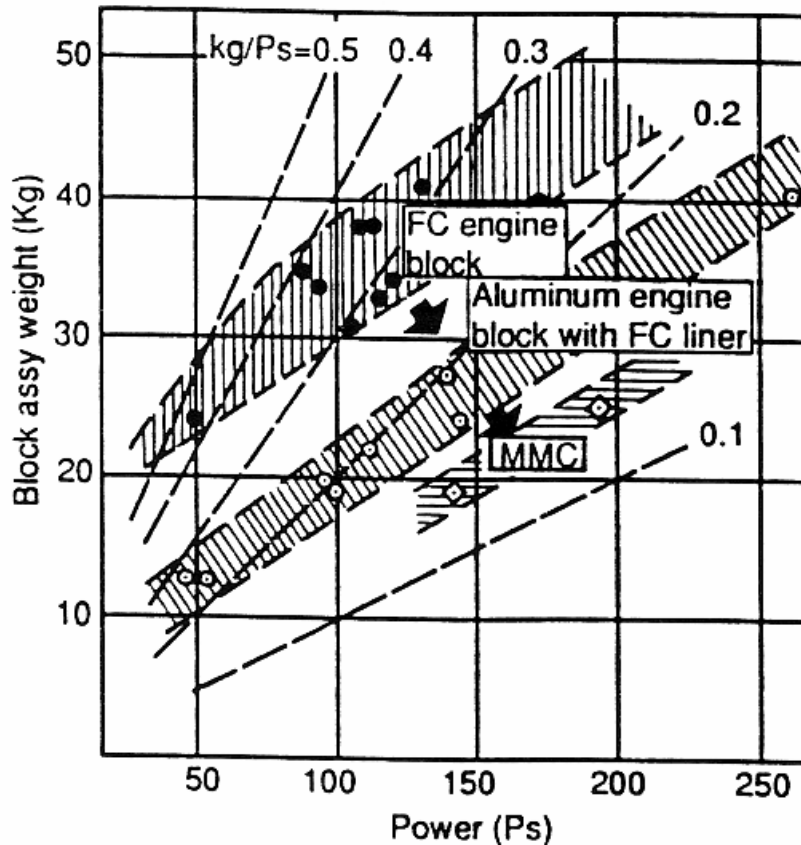
A porous hybrid material made out of
Short alumina and Carbon fibers

- Ceramic “preform” production
- Pressure casting process
- Honing



M. Ebisawa et. al, “The Production Process for MMC Engine Block”, SAE 910835

Relationship between Power and engine block weight



The new engine block features higher performance, further compactness and weight reduction compared to cast-iron engine blocks and those made out of Al alloy with cast-iron liners

M. Ebisawa et. al, "The Production Process for MMC Engine Block", SAE 910835

Commercial Applications of Al MMCs

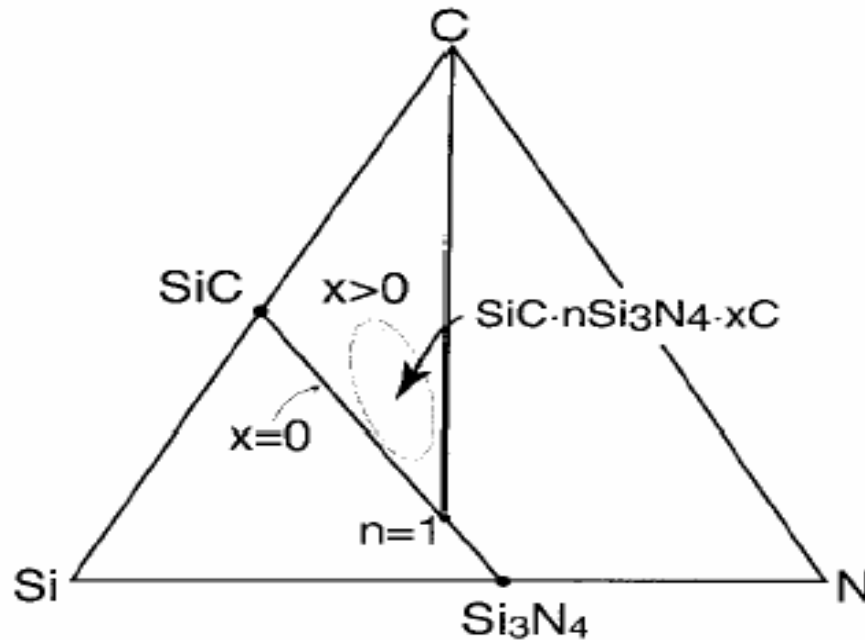
| Manufacturer | Component & Composite |
|------------------------------------|--|
| Duralcan, Martin Marietta, Lanxide | Pistons, Al/SiC _p |
| Duralcan, Lanxide | Brake rotors, calipers, liners, Al/SiC _p |
| GKN, Duralcan | Propeller shaft, Al/SiC _p |
| Nissan | Connecting rod, Al/SiC_w |
| Dow Chemical | Sprockets, pulleys, covers, Mg/SiC _p |
| Toyota | Piston rings, Al/Al ₂ O ₃ (saffil) & Al/Boria _w |
| Dupont, Chrysler | Connecting rods, Al/Al ₂ O ₃ |
| Hitachi | Current collectors, Cu/graphite |
| Associated Engineering, Inc. | Cylinders, pistons, Al/graphite |
| Martin Marietta | Pistons, connecting rods, Al/TiC _p |
| Zollner | Pistons, Al/fiberfrax |
| Honda | Engine blocks, Al/Al₂O₃ – C_f |
| Lotus Elise, Volkswagon | Brake rotors, Al/SiC _p |
| Chrysler | Brake rotors, Al/SiC _p |
| GM | Rear brake drum for EV-1, driveshaft, engine cradle, Al/SiC _p |
| MC-21, Dia-Compe, Manitou | Bicycle fork brace and disk brake rotors, Al/SiC _p |
| 3M | Missile fins, aircraft electrical access door, Al/Nextel _f |
| Knorr-Bremse; Kobenhavn | Brake disc on ICE bogies, SiC/Al |
| Alcoa Innometalx | Multichip electronic module, Al/SiC _p |
| Lanxide | PCB Heat sinks, Al/SiC _p |
| Cercast | Electronic packages, Al/graphite foam |
| Textron Specialty Materials | PCB heat sinks, Al/B |



Polymer-Derived Ceramics

Work in collaboration with the University of Colorado at Boulder
Professor Rishi Raj

Composition diagram and the properties of SiCN PDC materials

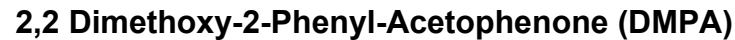


| | SiCN | SiC | Si ₃ N ₄ |
|---|--------------------|--------------------|--------------------------------|
| Density (g/cm ³) | 2.35 | 3.17 | 3.19 |
| E Modulus (GPa) | 150 | 405 | 314 |
| Poisson's Ratio | 0.17 | 0.14 | 0.24 |
| CTE (x 10 ⁻⁶ /K) | ~ 3 | 3.8 | 2.5 |
| Hardness (GPa) | 25 | 30 | 28 |
| Strength (MPa) | 1100 | 418 | 700 |
| Toughness (MPa.m ^{1/2}) | 3.5 | 4 - 6 | 5 - 8 |
| Thermal Shock FOM* | 2300 | 270 | 890 |
| Creep rate at 1350 °C (s ⁻¹) | < 10 ⁻⁸ | ~ 10 ⁻⁹ | ~ 10 ⁻⁹ |
| Oxidation rate at 1350 °C (cm/hr ^{1/2}) | ~ 10 ⁻⁵ | ~ 10 ⁻⁵ | ~ 10 ⁻⁵ |

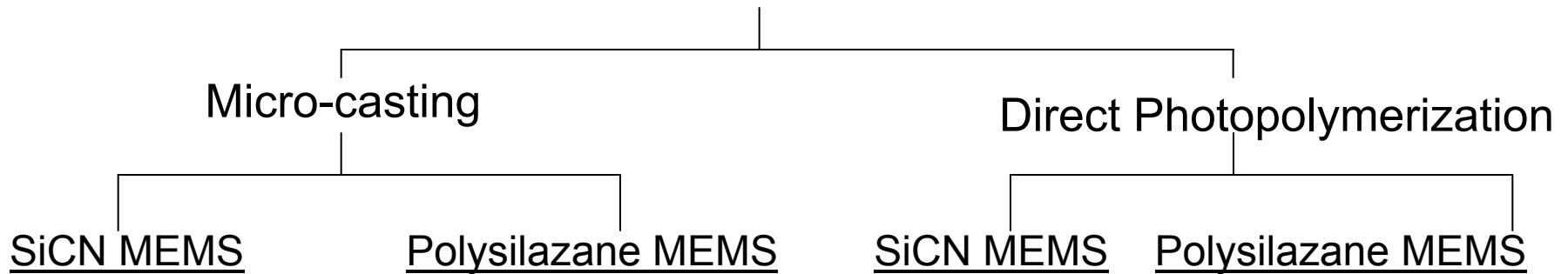
* strength/(E-modulus.CTE)

Raj et. al.

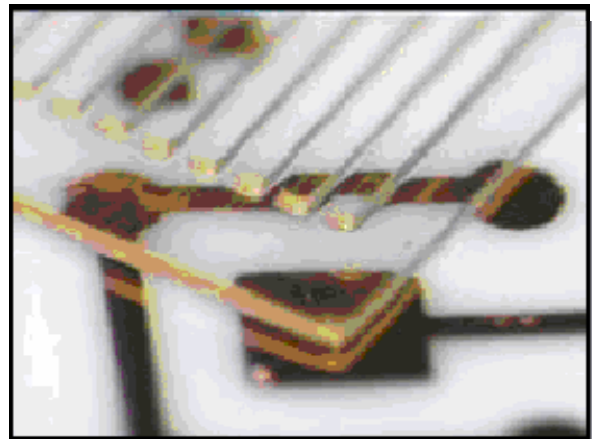
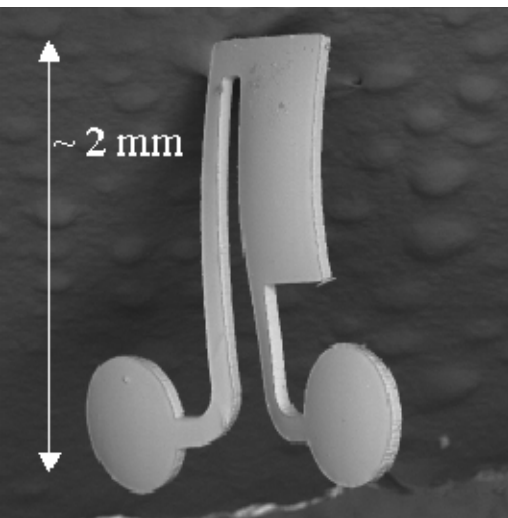
Fabri



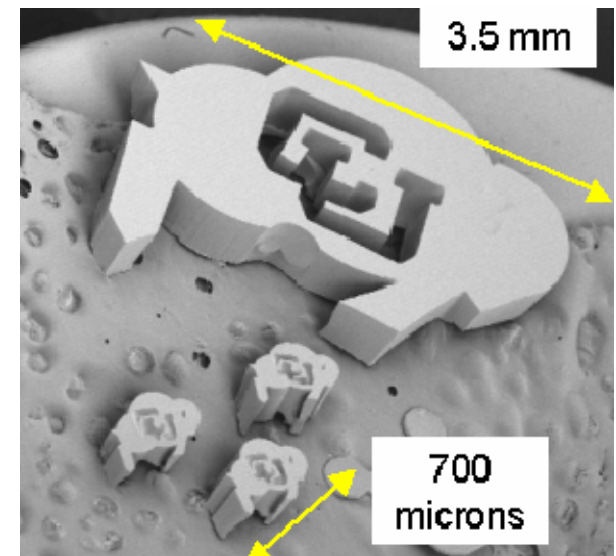
Polymer Micromachining



Cast in SU8 molds, followed
by de-molding

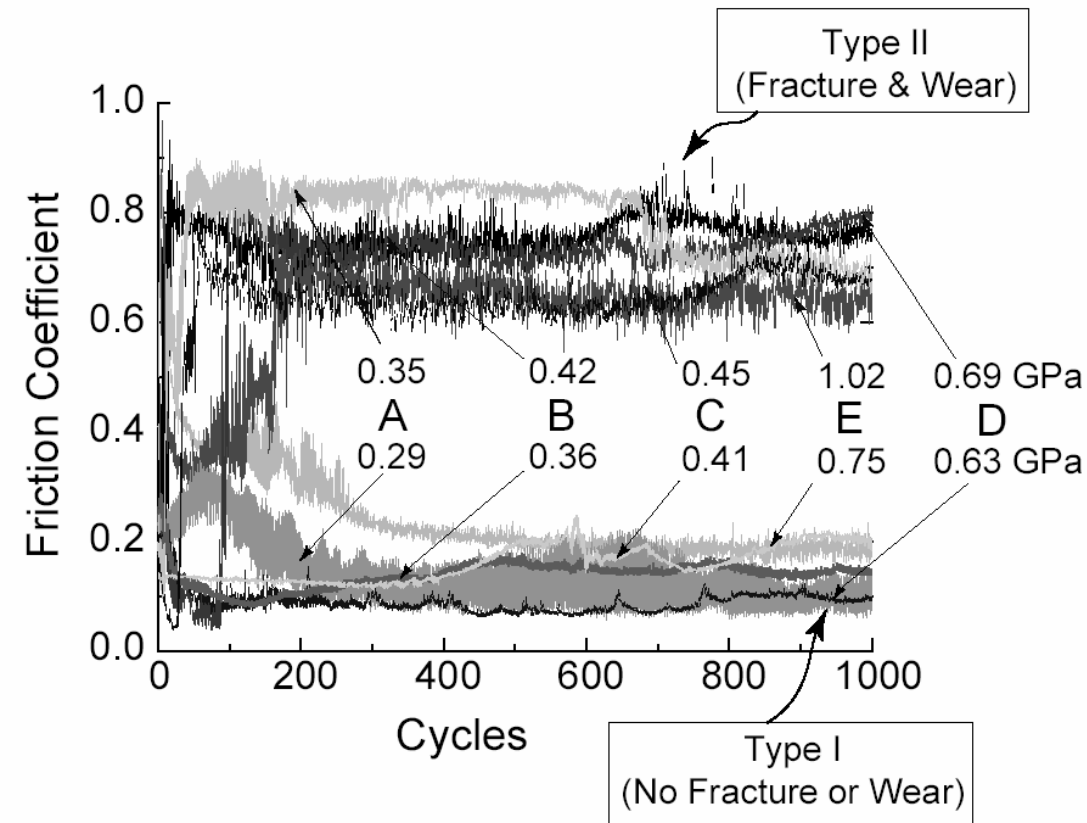


Treat precursor as a negative
photoresist

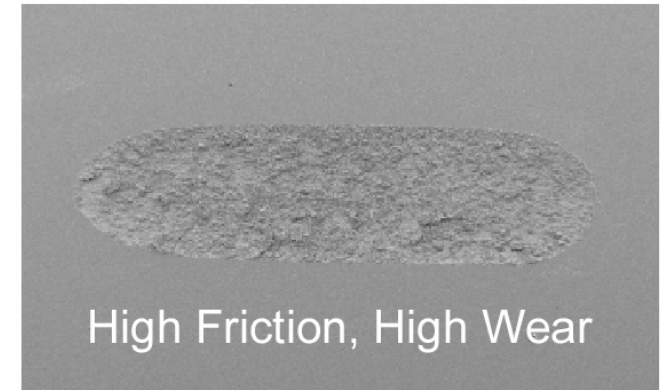


Preceramic polymer buffaloes, 500
microns thick

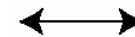
Friction behavior in dry nitrogen



Type II: 0.97 GPa, $\mu \sim 0.7$



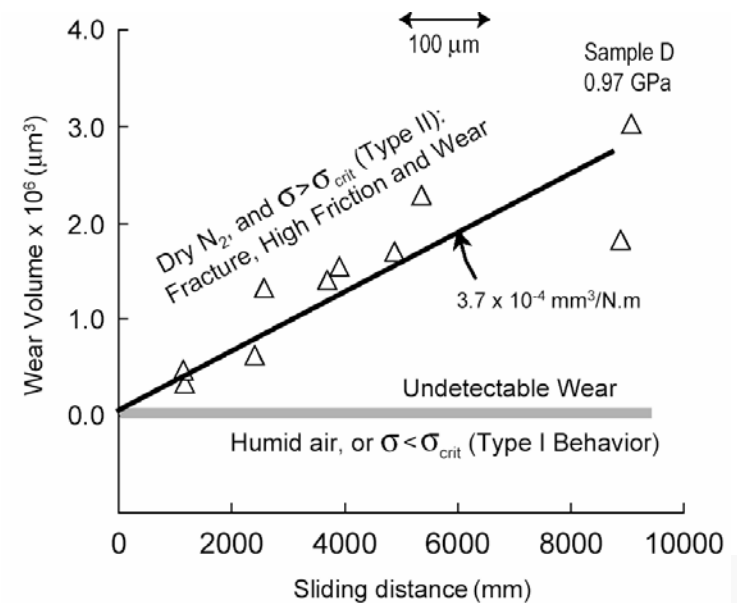
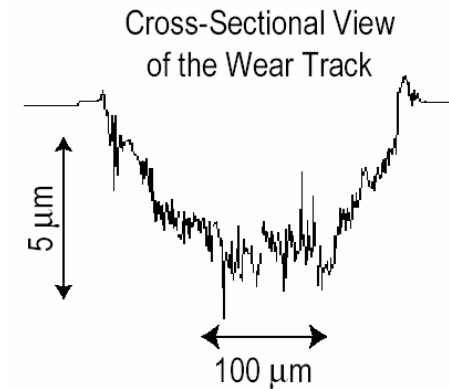
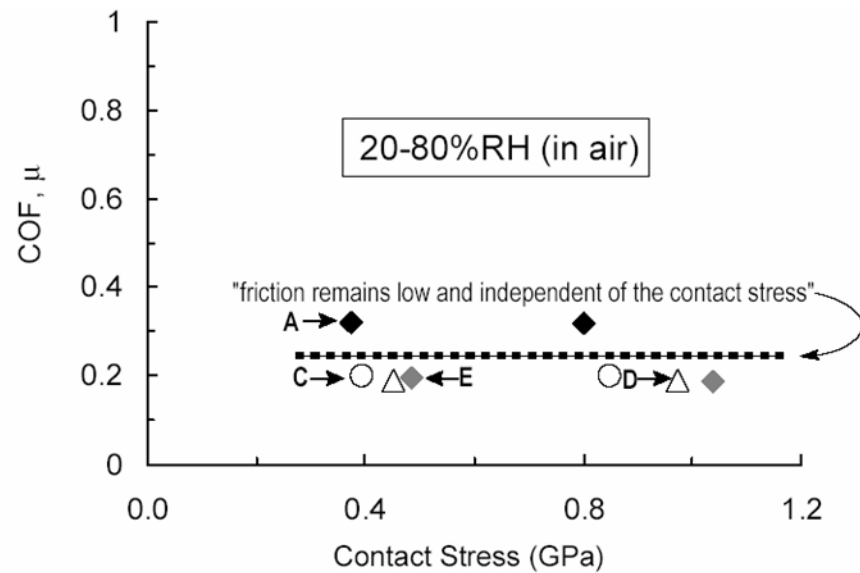
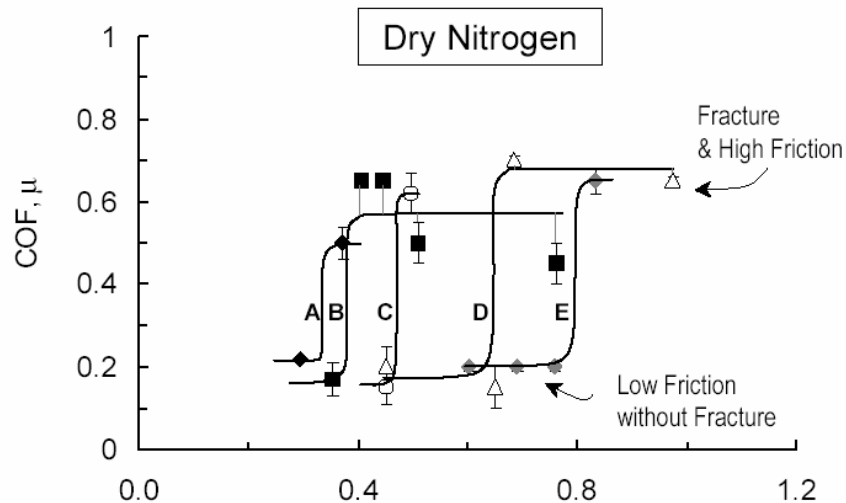
200 μm



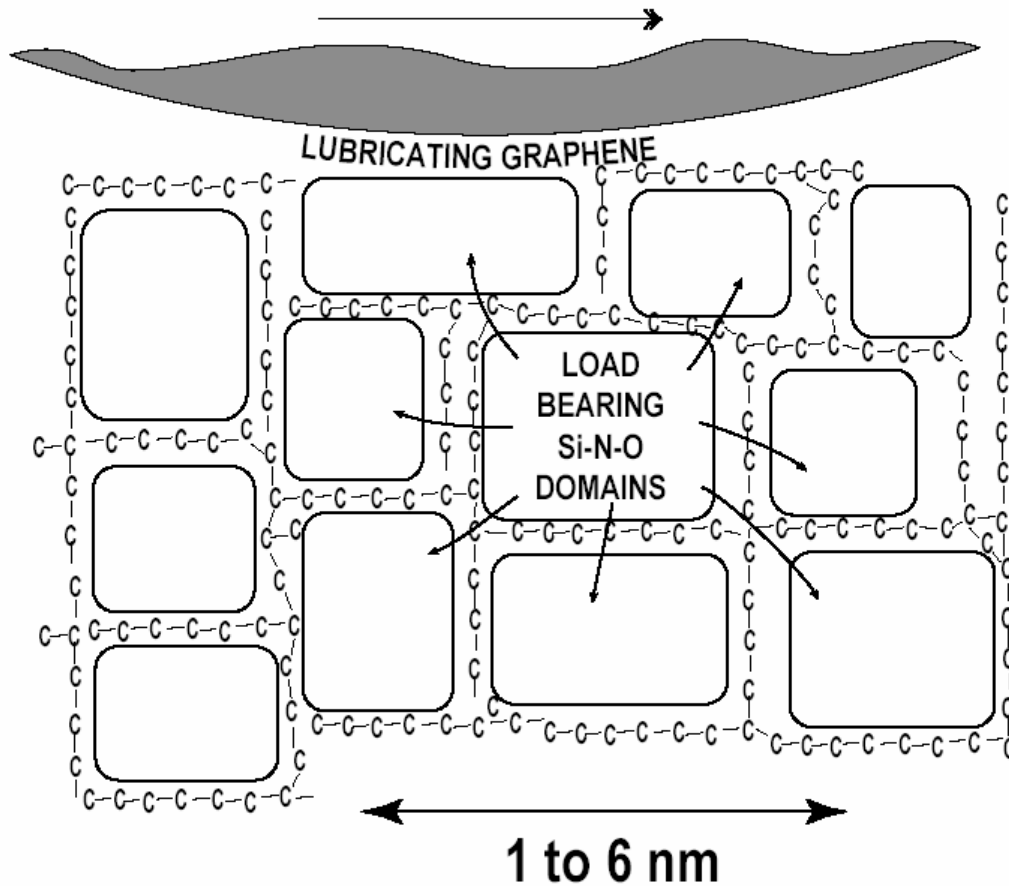
Type I: 0.36 GPa, $\mu \sim 0.2$



Environmental effects on friction and wear transitions



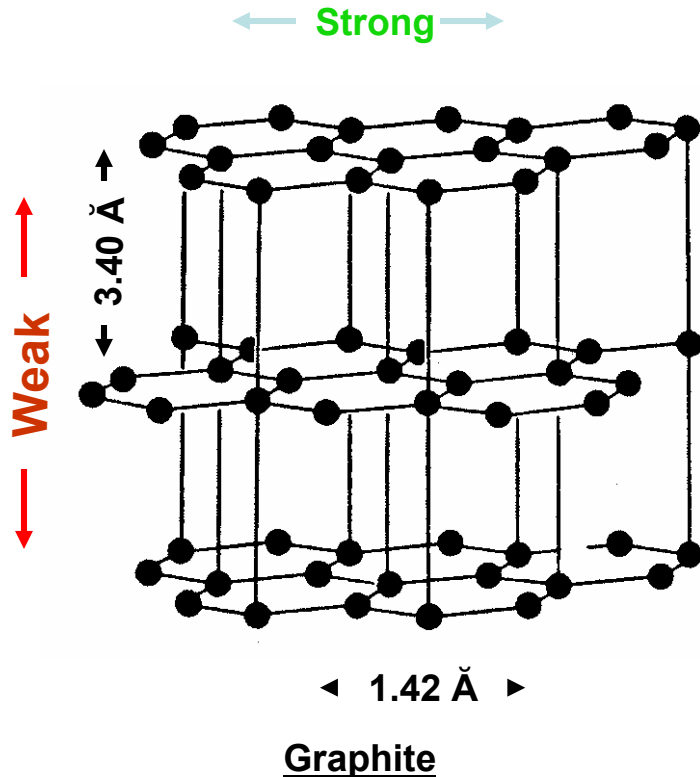
Schematic depiction of dual-phase structure in SiCNO





Solid Lubricants

Lubrication by graphite

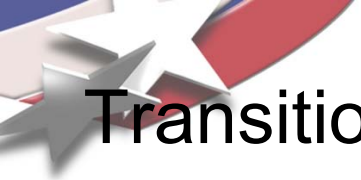


Element C (four valence electrons) can exist in different allotropic forms

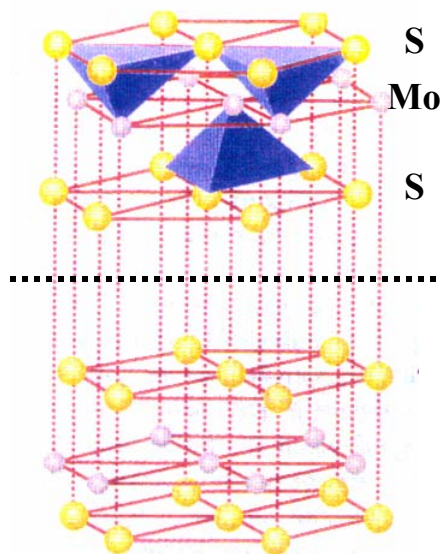
- sp^2 bonding configuration (crystalline graphite as shown in the right): basal planes held with strong covalent bonds, while the planes are held with weak Van der Waals forces. This gives rise to **interlamellar mechanical weakness**. Other sp^2 kinds include: carbon-carbon composites, unhydrogenated carbon, etc.
- sp^3 bonding in diamond
- Hydrogenated carbon with various degrees of sp^2/sp^3 bond ratios that are commonly known as diamond-like carbon.

Graphite needs moisture or adsorbed gases in the environment (>100 ppm) (they either act as intercalants, or passivate the dangling covalent bonds) to lubricate.

In vacuum, graphite exhibits high friction and wear—a phenomenon known as “dusting”, first observed in the late 1930’s when graphite brushes in aircrafts experienced accelerated wear at high altitudes.

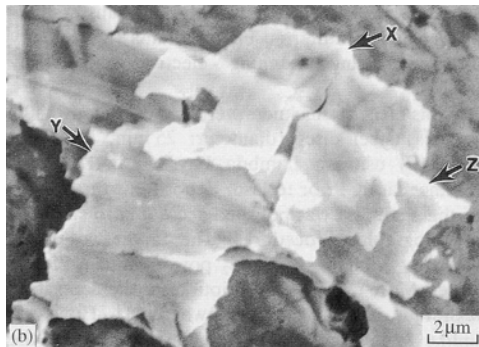
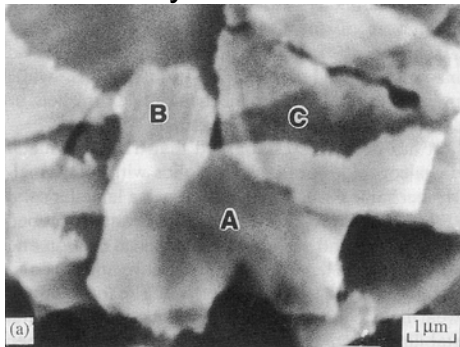


Transition metal dichalcogenides (MoS_2 , WS_2)

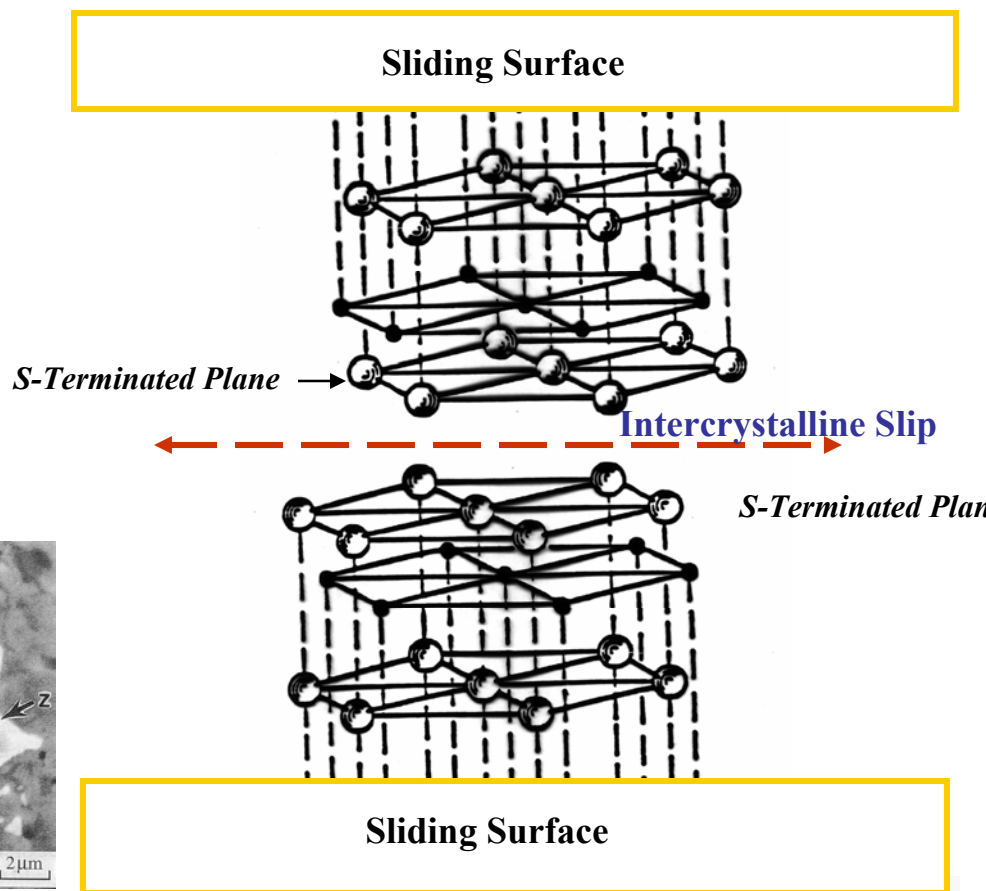


Mo/W Disulfide

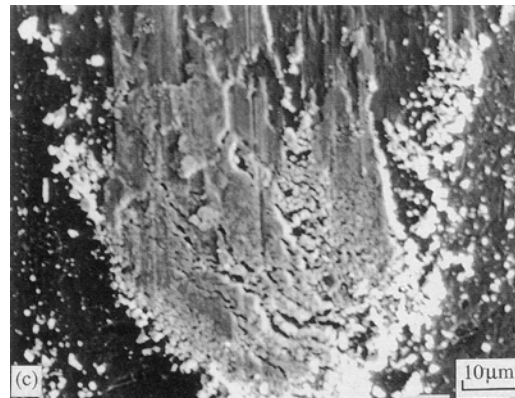
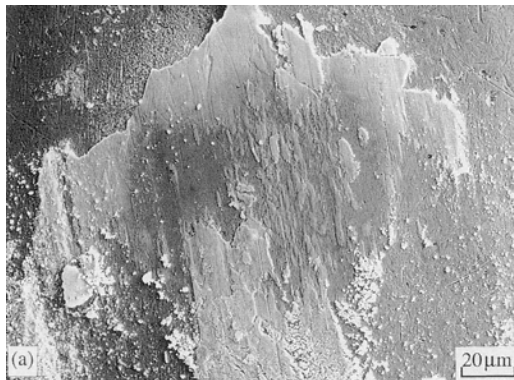
They form thin transfer films on the counterface



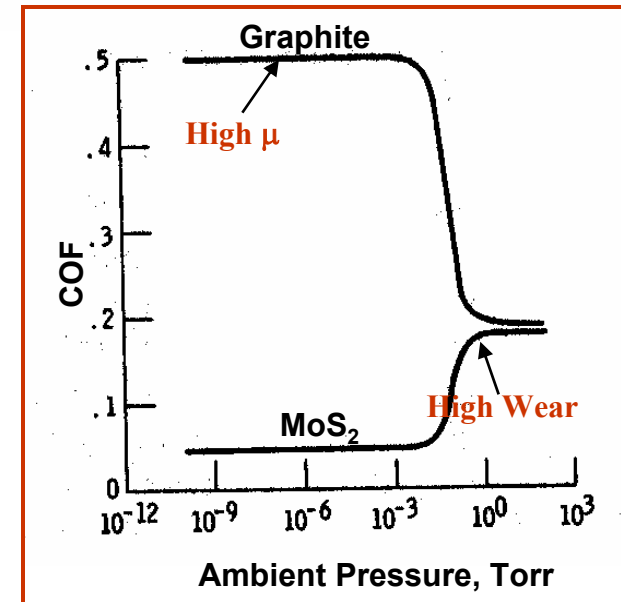
Extremely low COF (0.01-0.05) and long wear life (millions of wear cycles for a micron thick MoS_2 film), **but only in dry environments.**



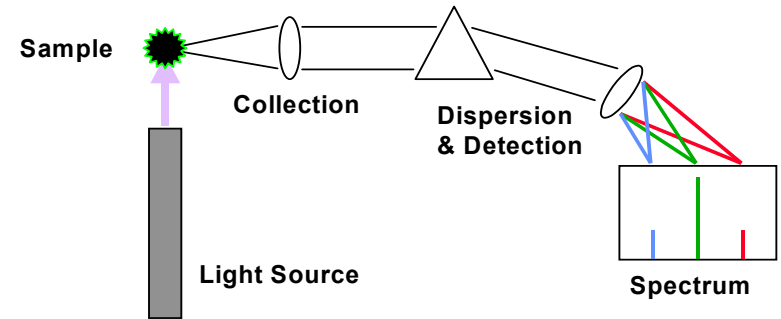
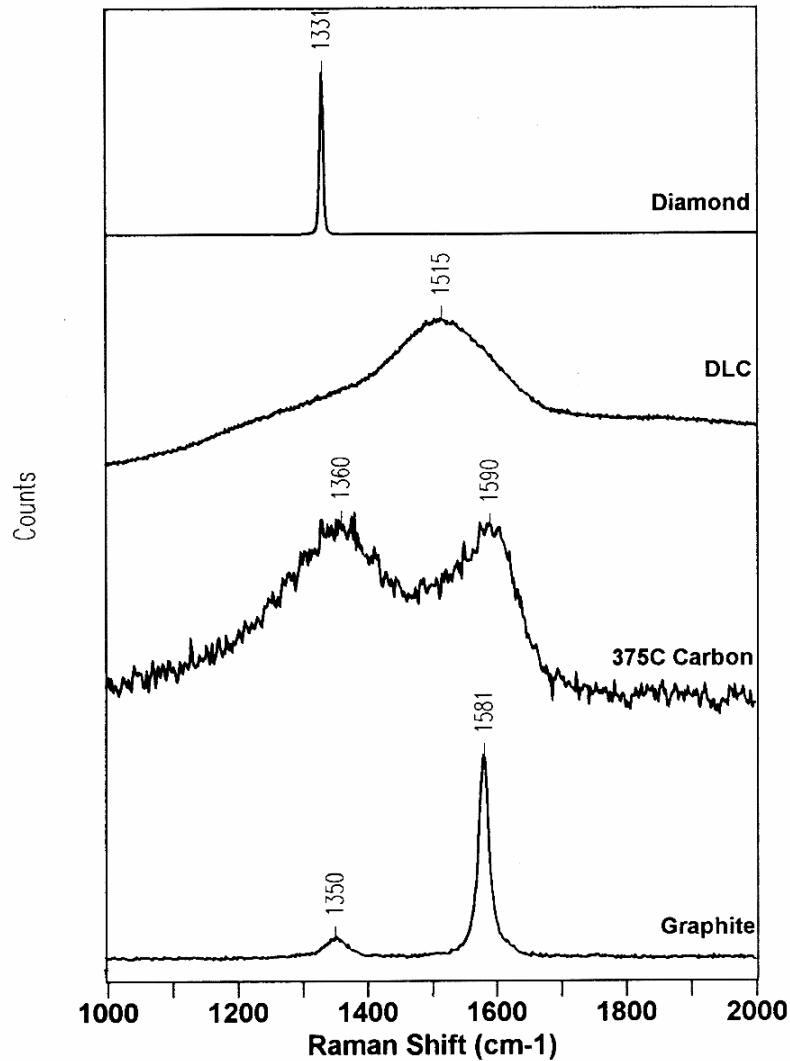
Oxidize in humid environments, losing their ability to lubricate



Typical transfer films (WS_2) in humid air



Carbon can exist in different forms



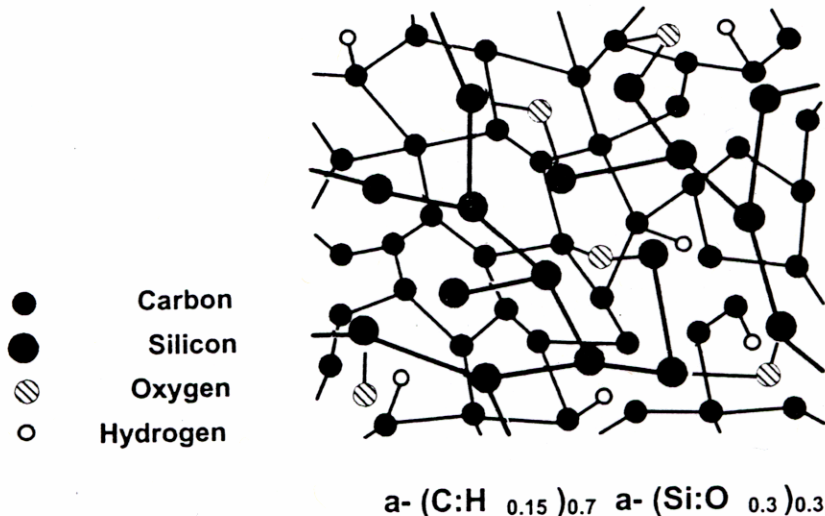
Argon laser: 458 nm wavelength
Spot size: 1 μm (Microscope Accessory)

D. R. Tallant et. al, *Diamond and Related Materials* 4 (1995) 191-199

Diamond like nanocomposite (DLN) coatings were produced by PECVD (Source: Bekart Advanced Coating Technologies)

Plasma Enhanced CVD

Polyphenylmethylosiloxane precursor



Schematic of DLN atomic structure.

Interpenetrating random networks
DLC ($a-C:H$) and glass like $a-Si:O$

- Conformal coatings could provide coverage of sidewalls
- Substrate temperatures do not typically exceed 150 to 200 °C

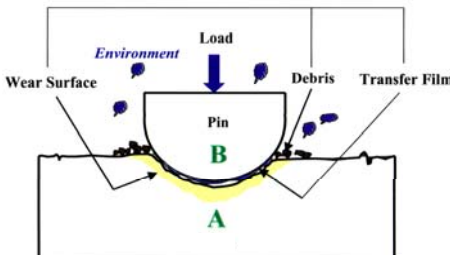
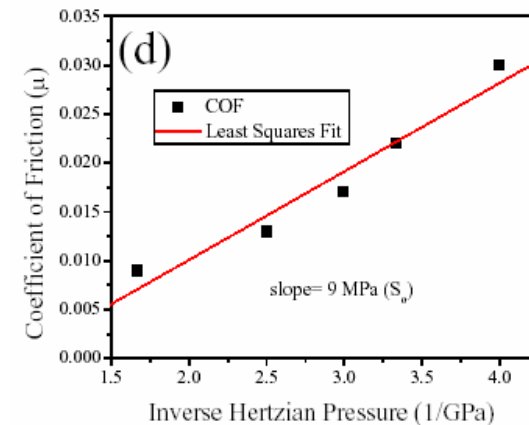
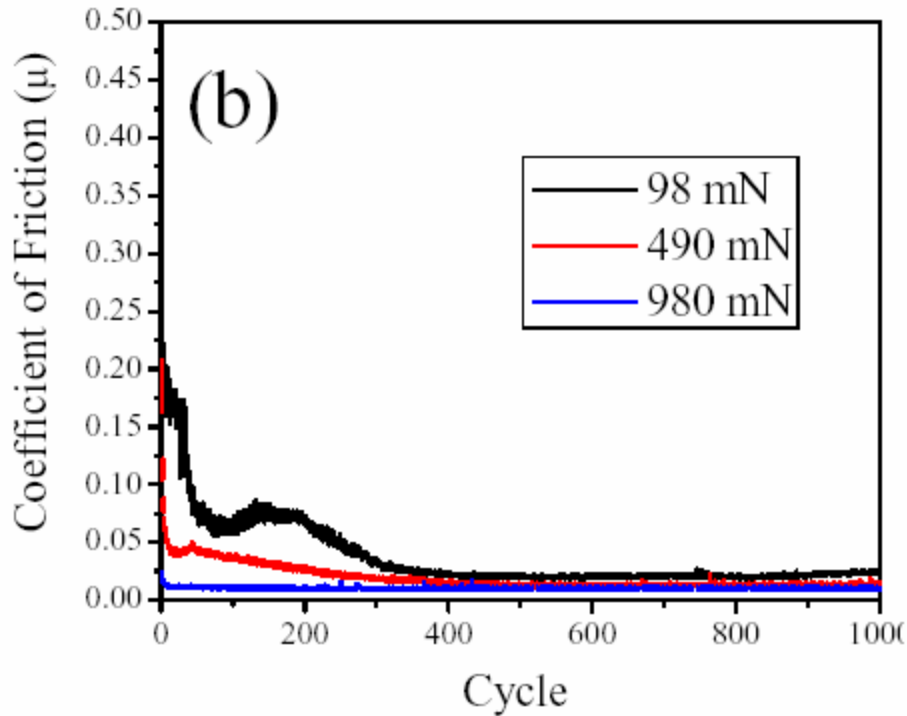
Hardness: 9-17 GPa
Modulus: 90-140 GPa

V. F. Dorfman, *Thin Solid Films*, 212 (1992) 267-273

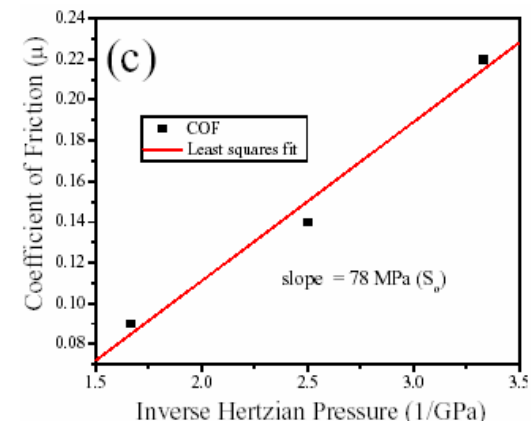
D. J. Kester, C. L. Brodbeck, I. L. Singer and A. Kyriakopoulos, *Surface and Coatings Tech.* 113 (1999) 268-273.

C. Venkatraman, C. Brodbeck and R. Lei, *Surface and Coatings Tech.* 115 (1999) 215-221.

Many solid lubricants exhibit non-Amontonian friction behavior

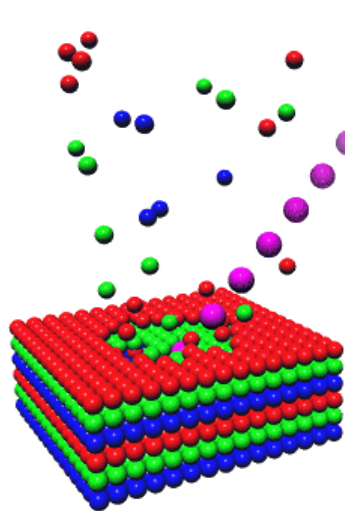


$$\mu = S_0/P + \alpha$$

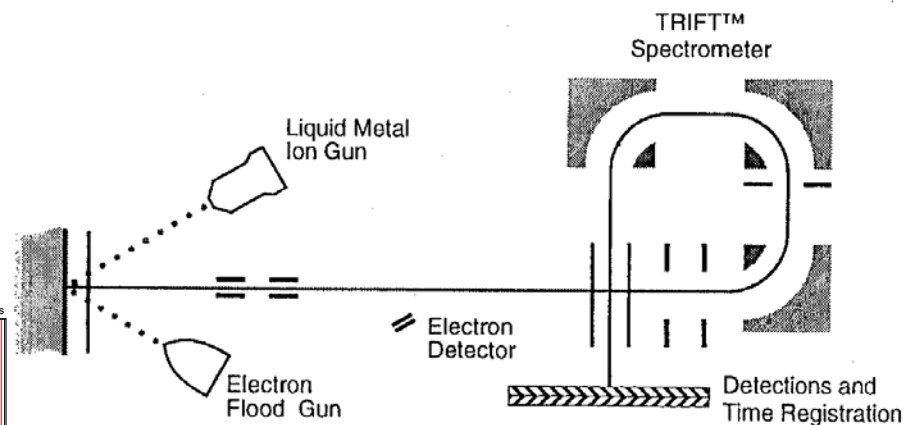
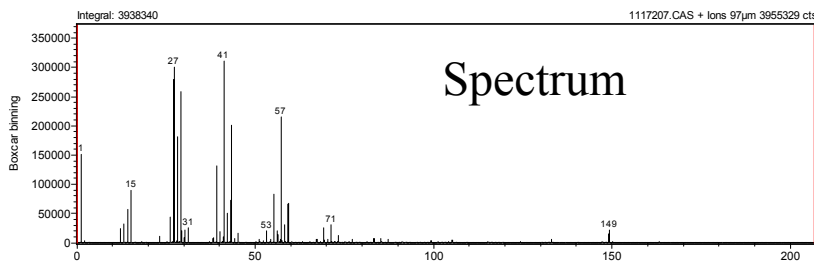
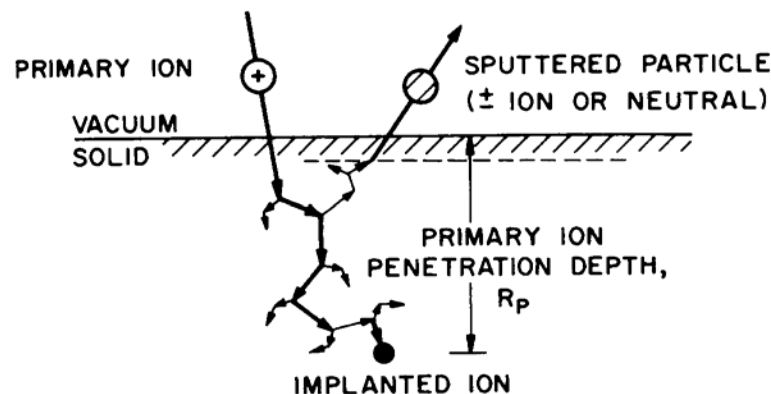


Time-of-Flight Secondary Ion Mass Spectrometry

+/- Ions and Neutrals
ejected from surface
(Elemental and Molecular)



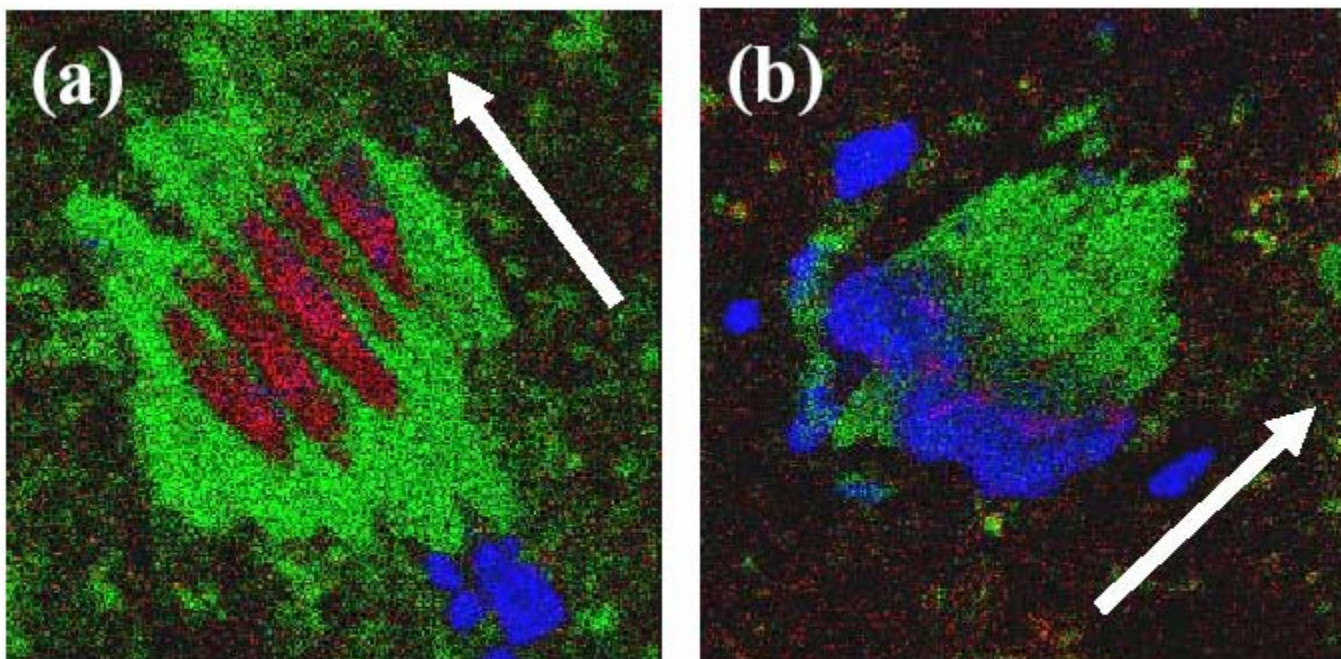
Ga^+ Primary Ions



Spectral Imaging and Multivariate Analysis

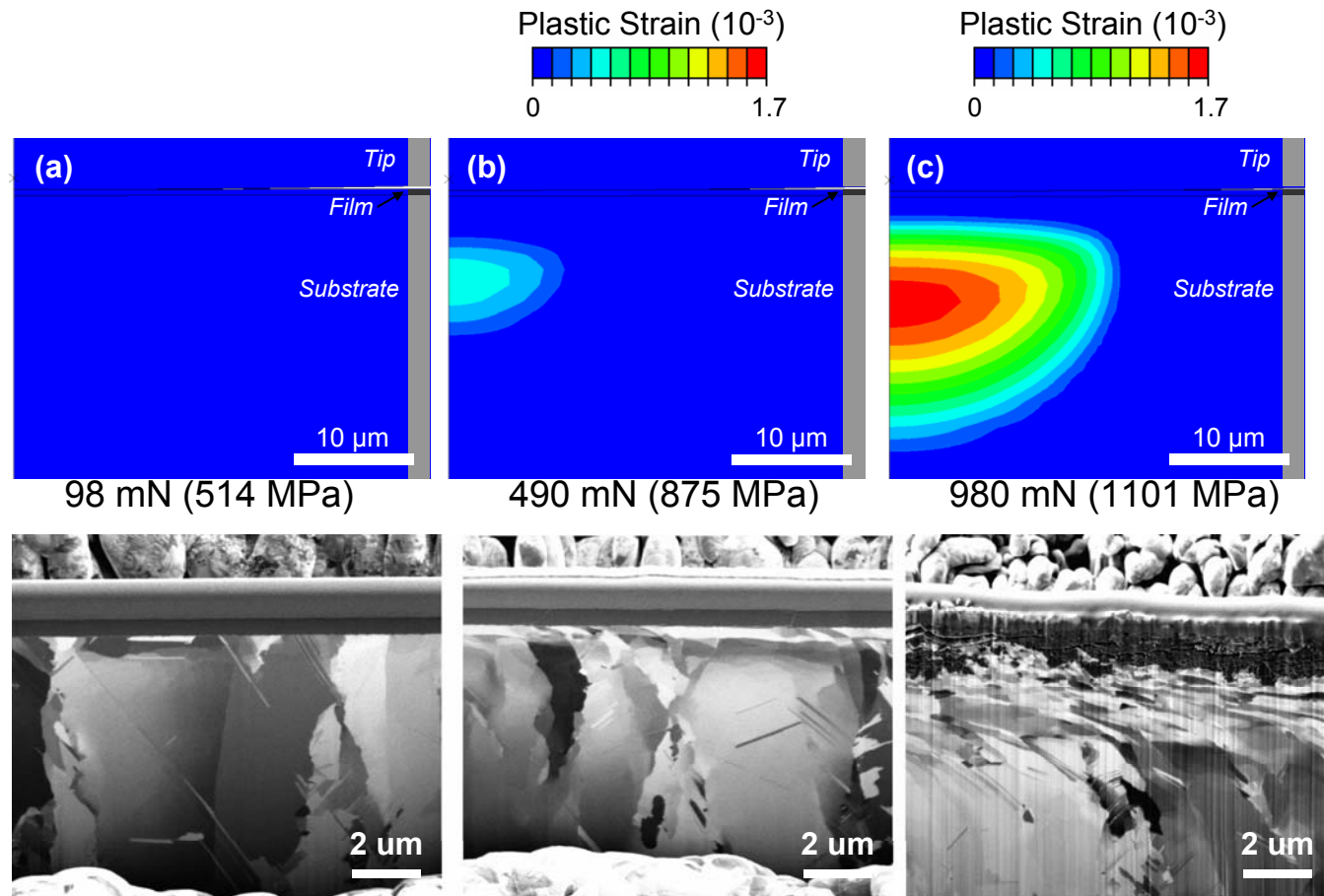
Wet

Dry



Red: SiO_2 (O + Si + SiO_2 + SiO_3)
Green: Long Range Carbon (C_1 to C_4 fragments)
Blue: Hydrogenated Carbon (CH + CH_2 + C_2H)

FEA and FIB can reveal the onset of substrate plastic deformation



Generation of plastic strain under 1/8" Si_3N_4 ball on DLN-coated Ni at peak contact stresses of (a) 507 MPa [98 mN], (b) 864 MPa [490 mN] and (c) 1088 MPa [980 mN].



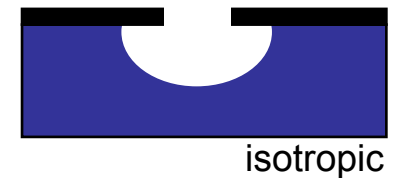
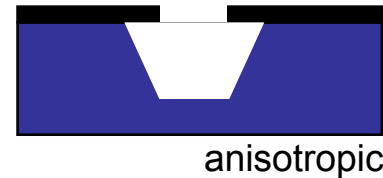
Tribological issues in MEMS

Microelectromechanical Systems (MEMS)

A variety of fabrication methods can be used to construct microsystems

Bulk Micromachining

- subtractive process; pattern and etch
- well established for Si; also done in GaAs

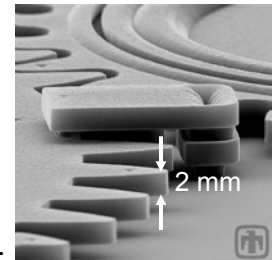


Surface Micromachining

- additive process; structural (Si) and sacrificial (SiO_2) layers
- dissolve sacrificial layers to free structures

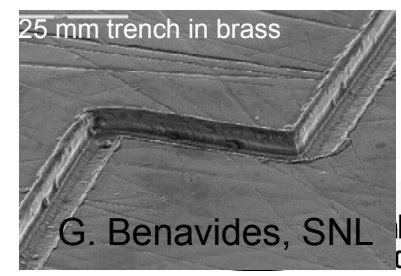
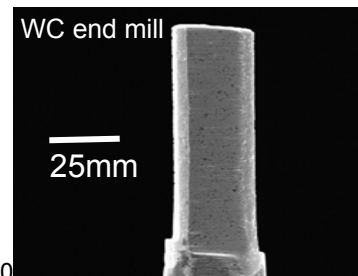
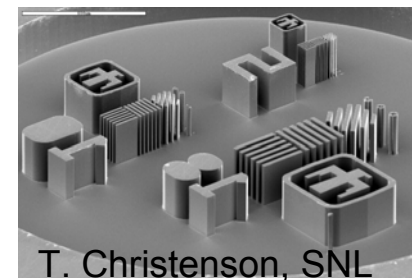
Lithographie, Galvanoformung und Abformung (LIGA)

- plate or press into thick polymer mold
- micron to centimeter scale parts



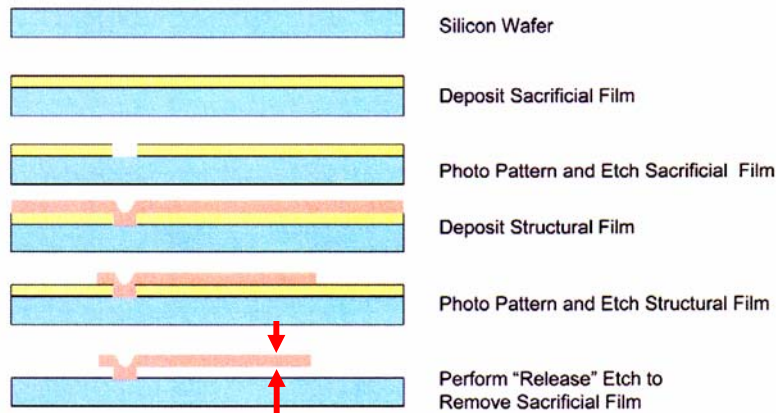
Meso-Machining

- subtractive process; push machining methods to micron scale
- micro-milling, micro-EDM, plunge EDM



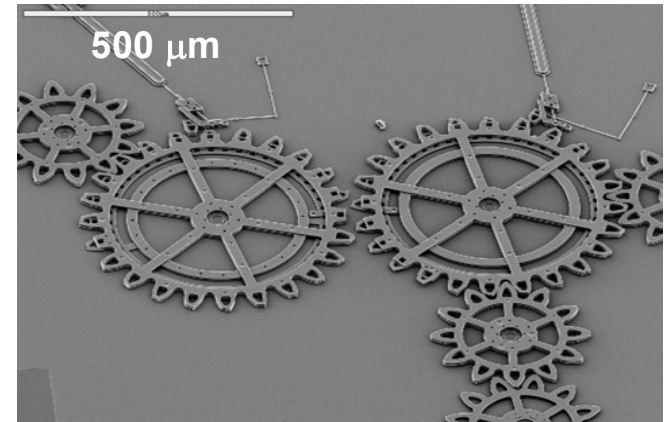
Surface Micromachined (SMM) Silicon Devices

Microfabrication with silicon leverages decades of process knowledge
Mature fabrication equipment and processes

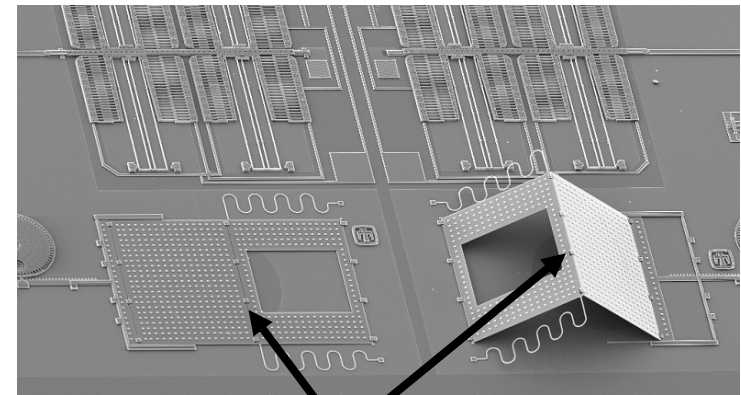


In-process adhesion (stiction) is no longer a significant barrier to successful device fabrication and initial operation

- **Dynamic Interfaces (Tribology)**
- **Dormancy and Materials Aging**
- **Surfaces (Buried/Hidden)**

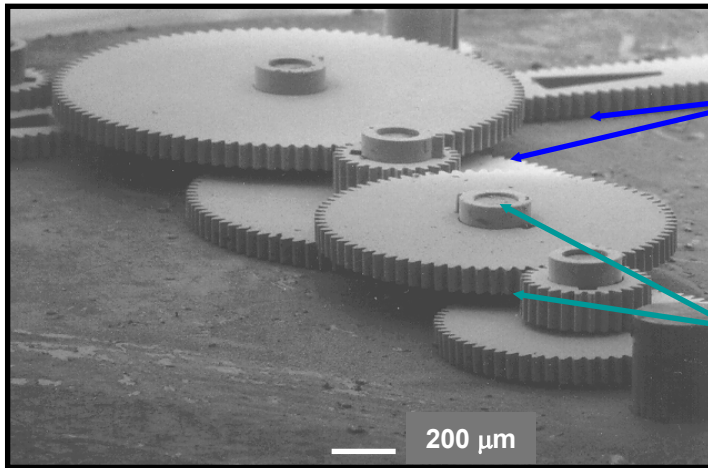


actuators, guides and gears used to achieve motion

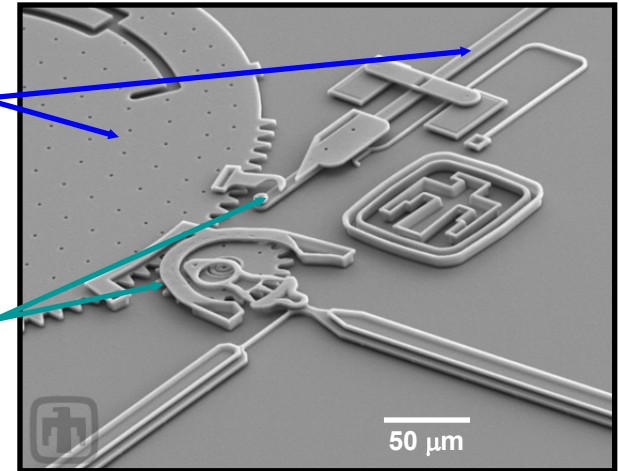


Hinges
Pop-up Mirrors

Microsystems frequently contain rubbing surfaces



Electroformed Ni transmission

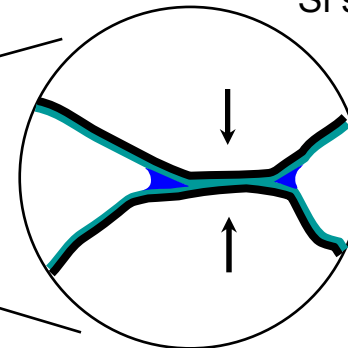
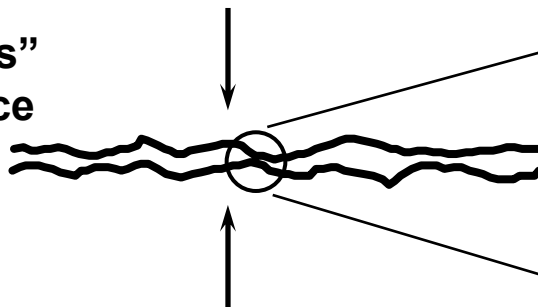


Si surface micromachined lock

Planar contact

Sidewall contact

“Macromachines”
applied force
inertia



“Micromachines”
applied force
capillary
electrostatic
Van der Waals

Surface interactions dominate as machine scale is reduced

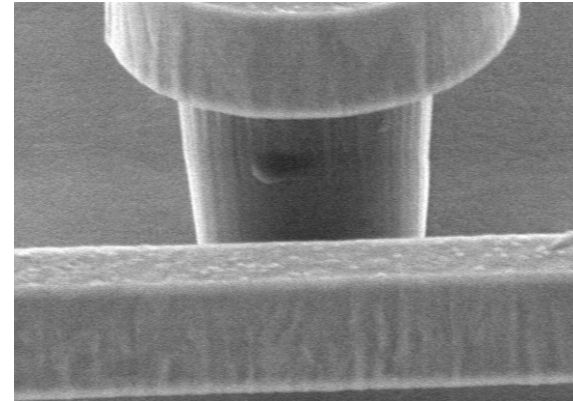
dormancy ↔ *friction, wear* → *reliability*

Apply novel, small scale experimental techniques to study tribology.

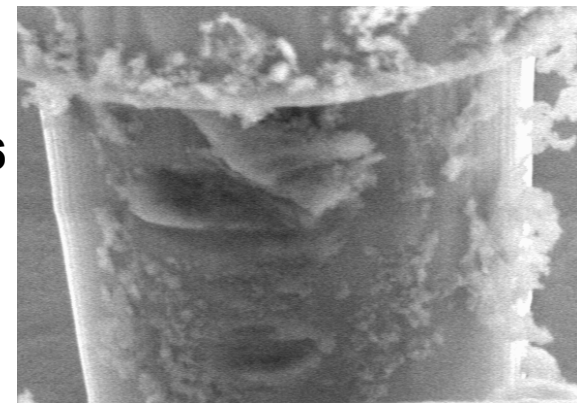
Friction evolution in FTS-coated devices exhibits a strong dependence on the presence of water vapor

Lubricated with
Perfluorodecyltrichlorosilane (FTS)
 $\text{CF}_3(\text{CF}_2)_7(\text{CH}_2)_2\text{SiCl}_3$

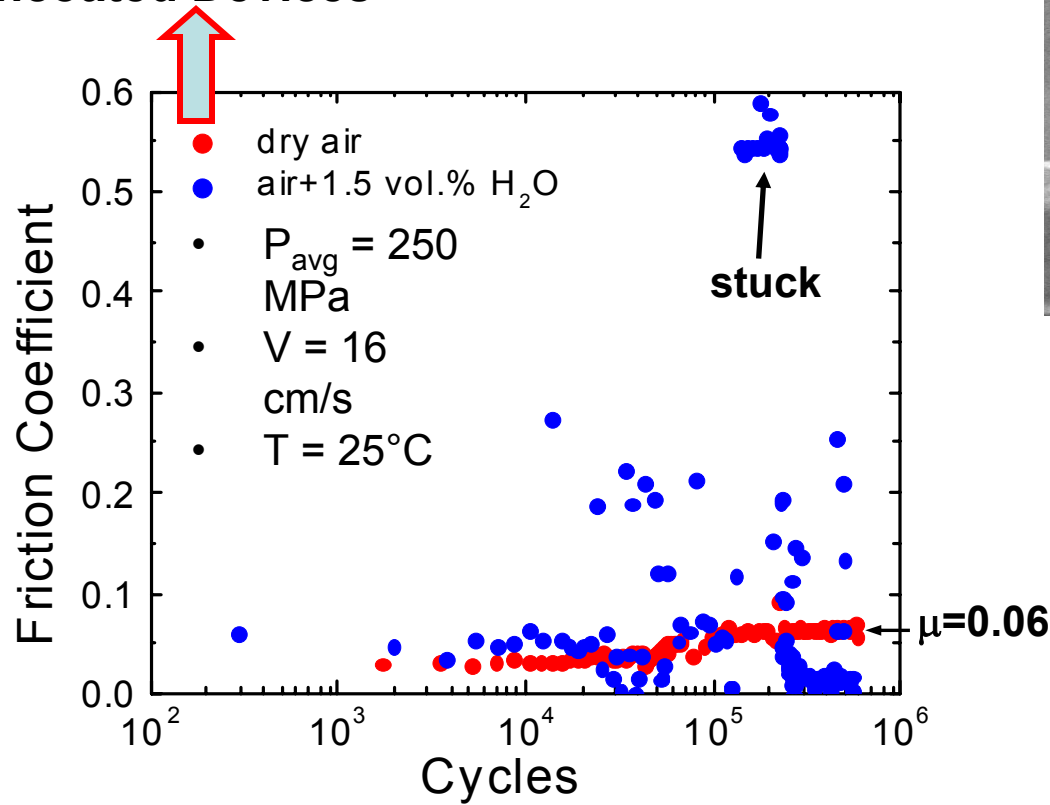
dry air (100 ppm H_2O)



air+1.5 vol.% H_2O (40%RH)



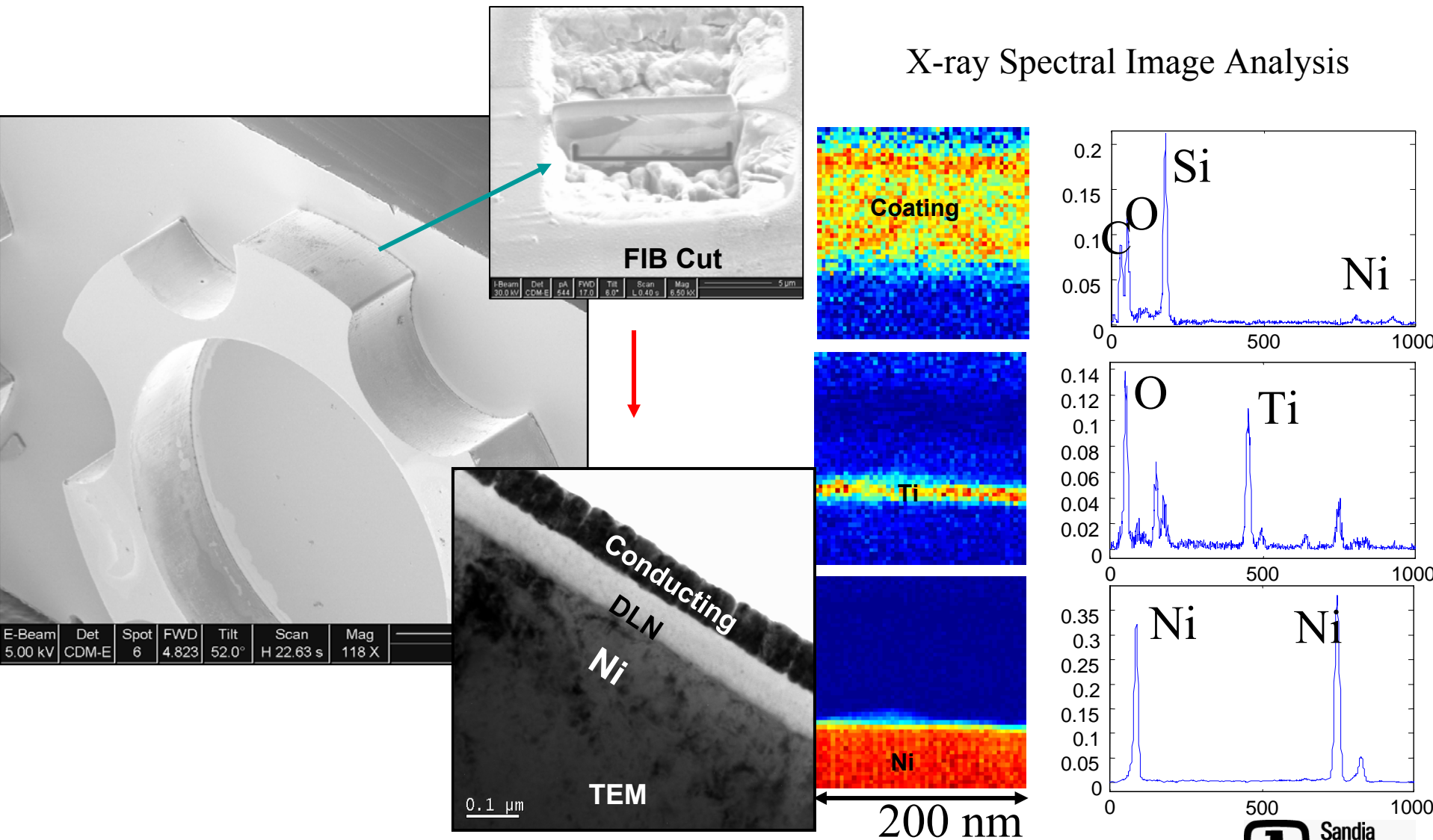
Uncoated Devices



Courtesy: M. T. Dugger (mtdugge@sandia.gov)

Romig AD, Dugger MT, McWhorter, Acta Materialia 51 (2003) 5837

Novel techniques are necessary to characterize the chemistry and coverage on the sidewalls of miniature parts

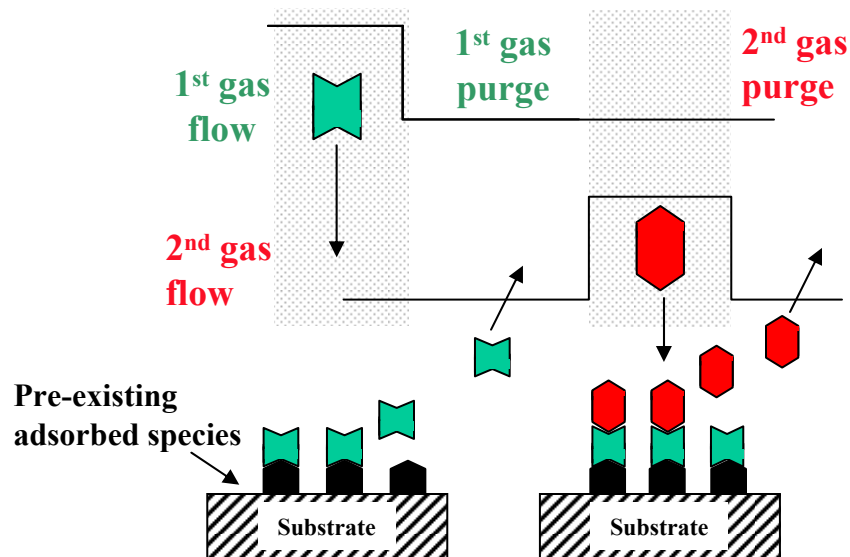




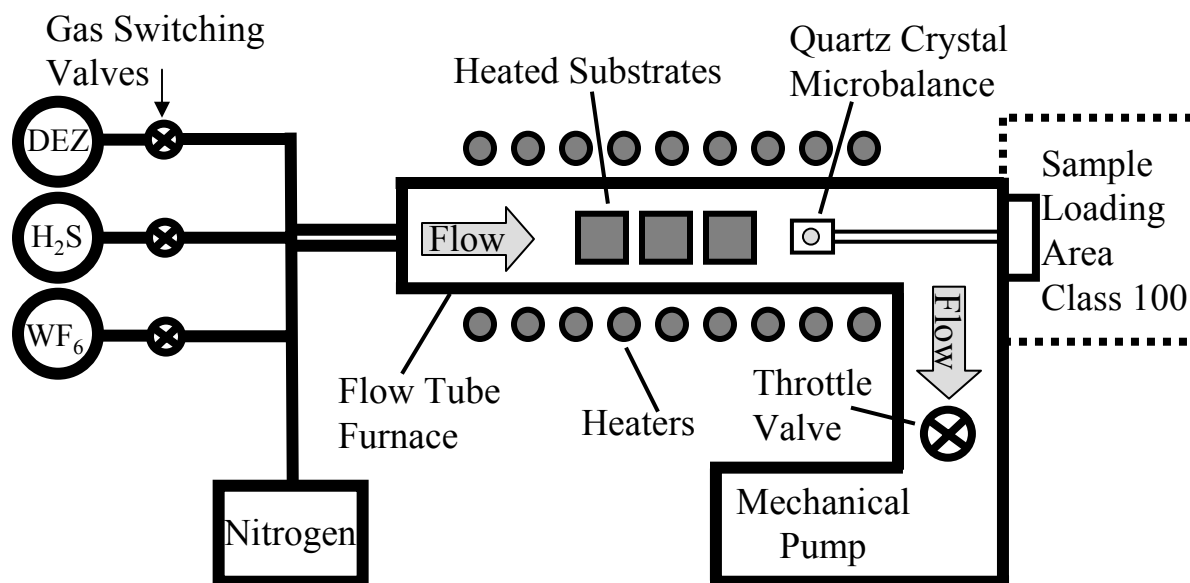
Atomic Layer Deposition (ALD)

Atomic Layer Deposition for Tribological Coatings

Atomic Layer Deposition (ALD) is based on sequential introduction of gaseous precursors and selective chemistry



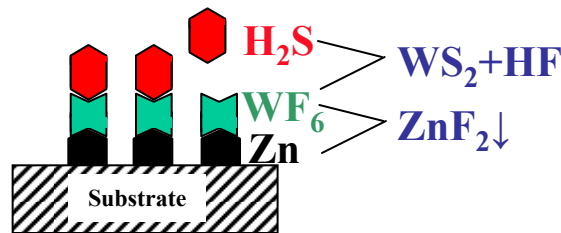
Schematic illustration of the ALD reactor for the synthesis of WS_2 films



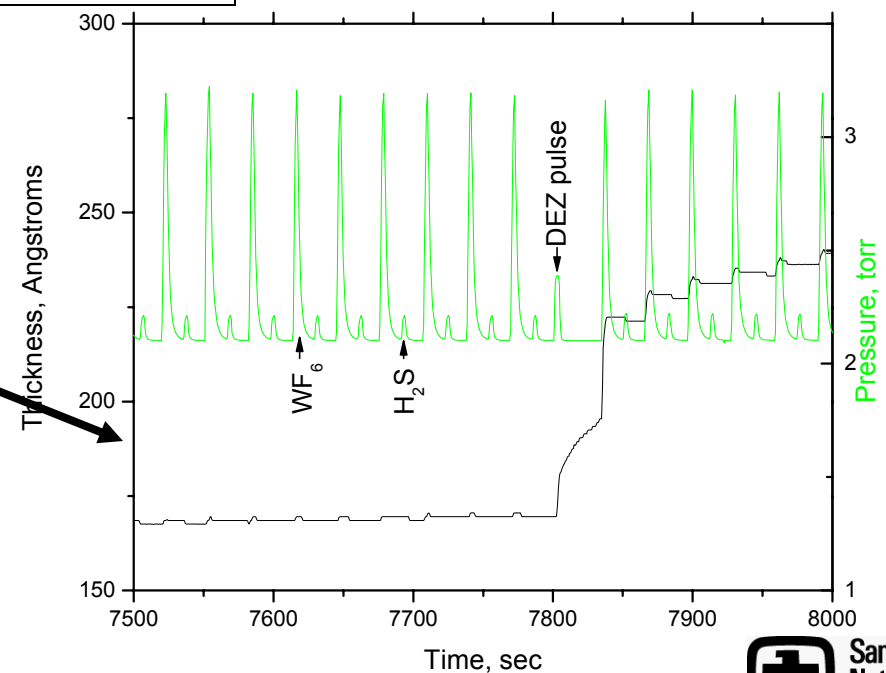
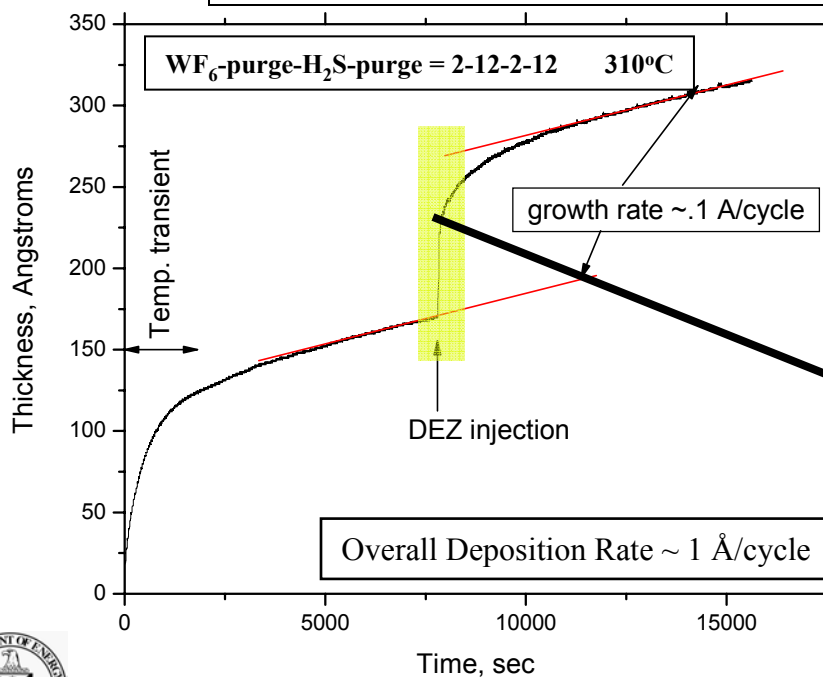
Quartz Crystal Microbalance Provides *in-situ* Process Diagnostics

ALD WS_2 is based on the CVD reaction: $\text{WF}_6 + \text{H}_2\text{S} \rightarrow \text{WS}_2 + \text{HF}$

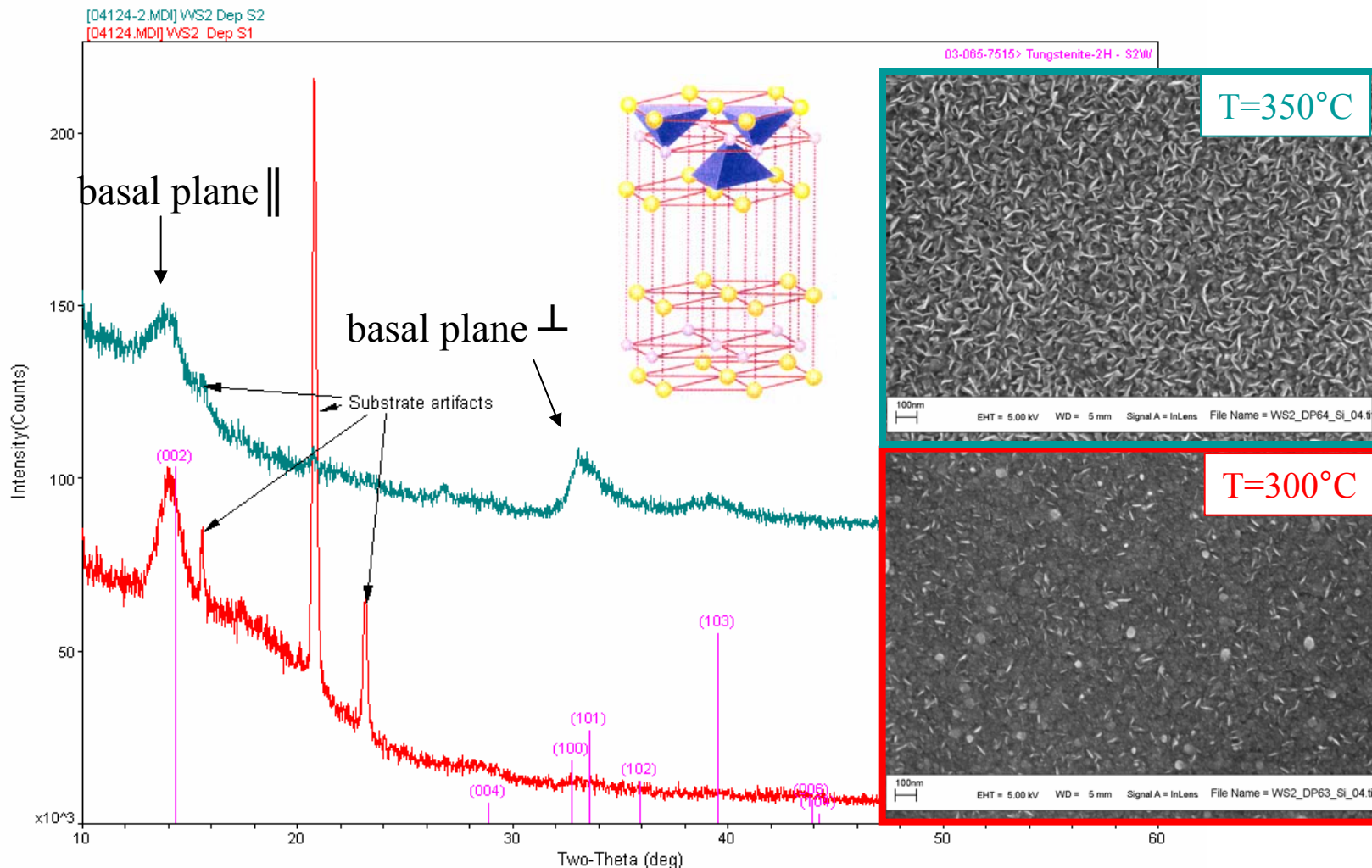
Zn catalyzed adsorption and reaction of WF_6 greatly increases WS_2 growth rate:



Recipe: 1 cycle of DEZ
followed by 50 cycles of
 $\text{WF}_6 + \text{H}_2\text{S}$



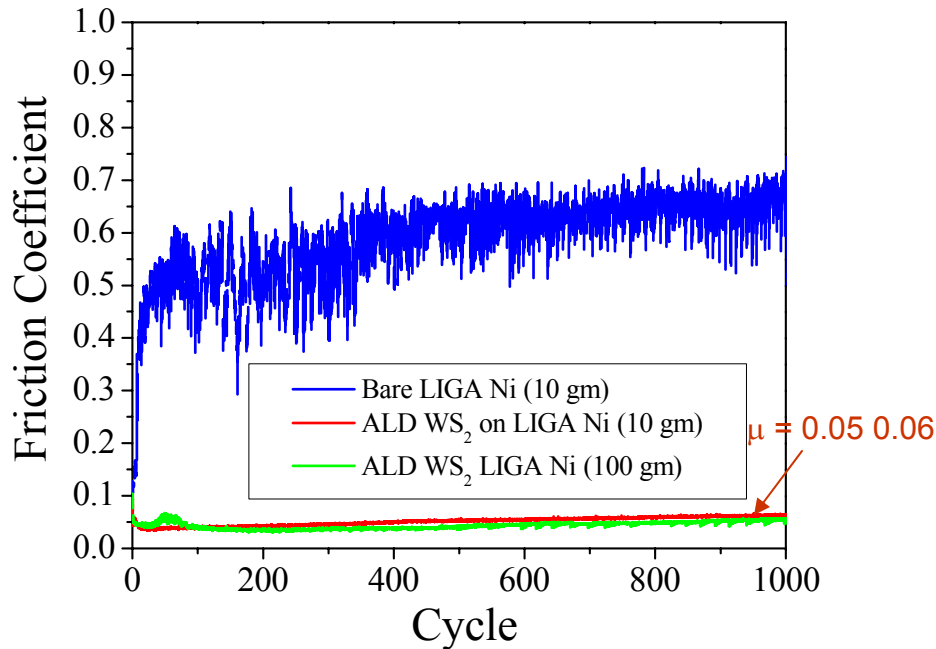
Crystallographic texture of ALD WS_2 is growth temperature dependent



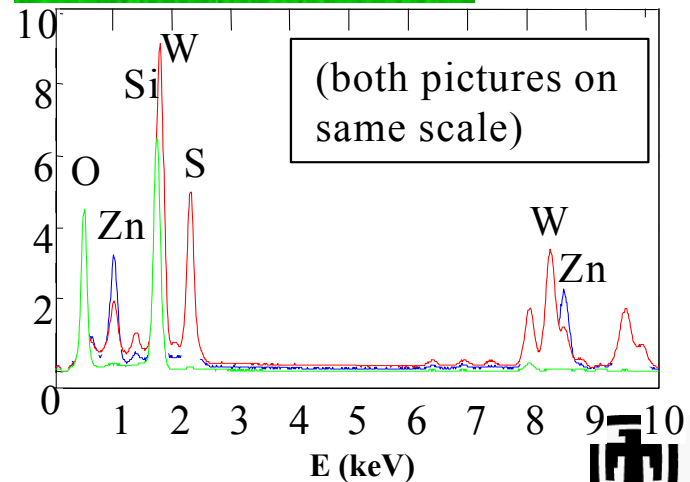
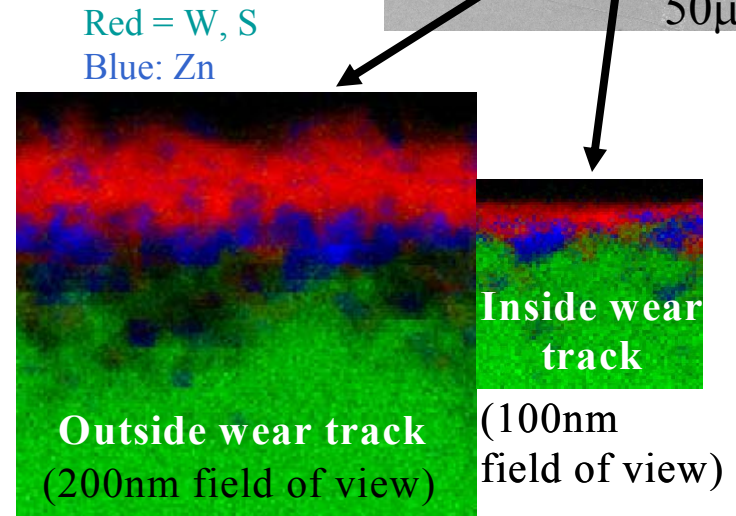
Basal plane preferred orientation effects as function of T

Tribology of ALD WS_2 Films

Friction

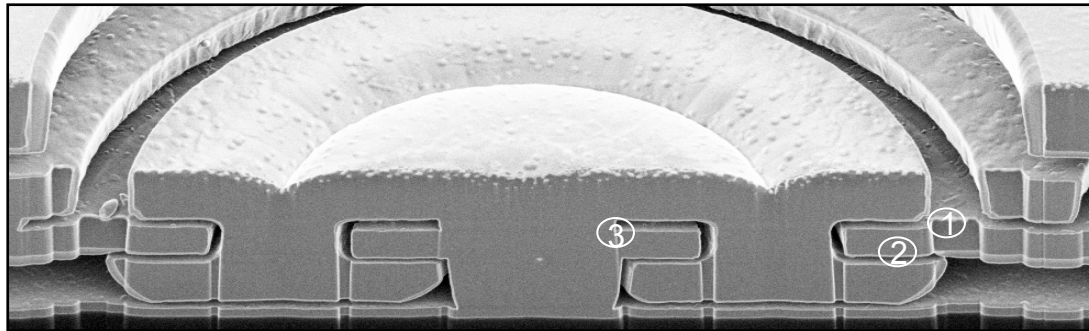


Spectral Images

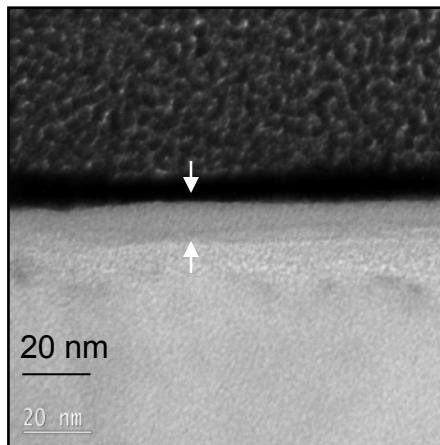


- We are able to grow ALD WS_2 films on a variety of substrates: Si, SiO_2 , Au, Stainless Steel, LIGA Ni
- Some of the wear taking place is a result of film material being transferred to the rubbing counterface (Si_3N_4).

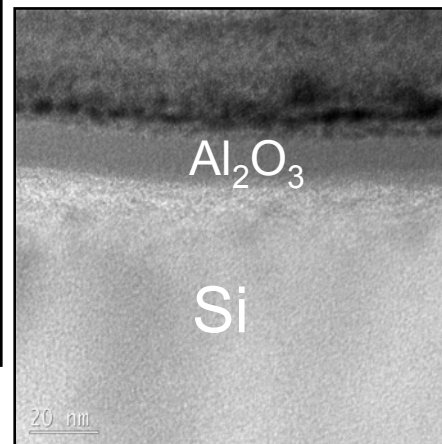
ALD conformally coats very high aspect ratio structures and buried interfaces



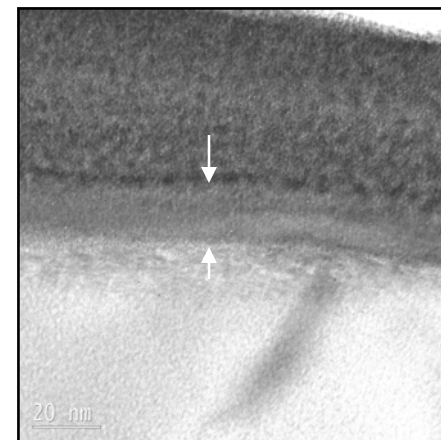
1. Gear top exposed



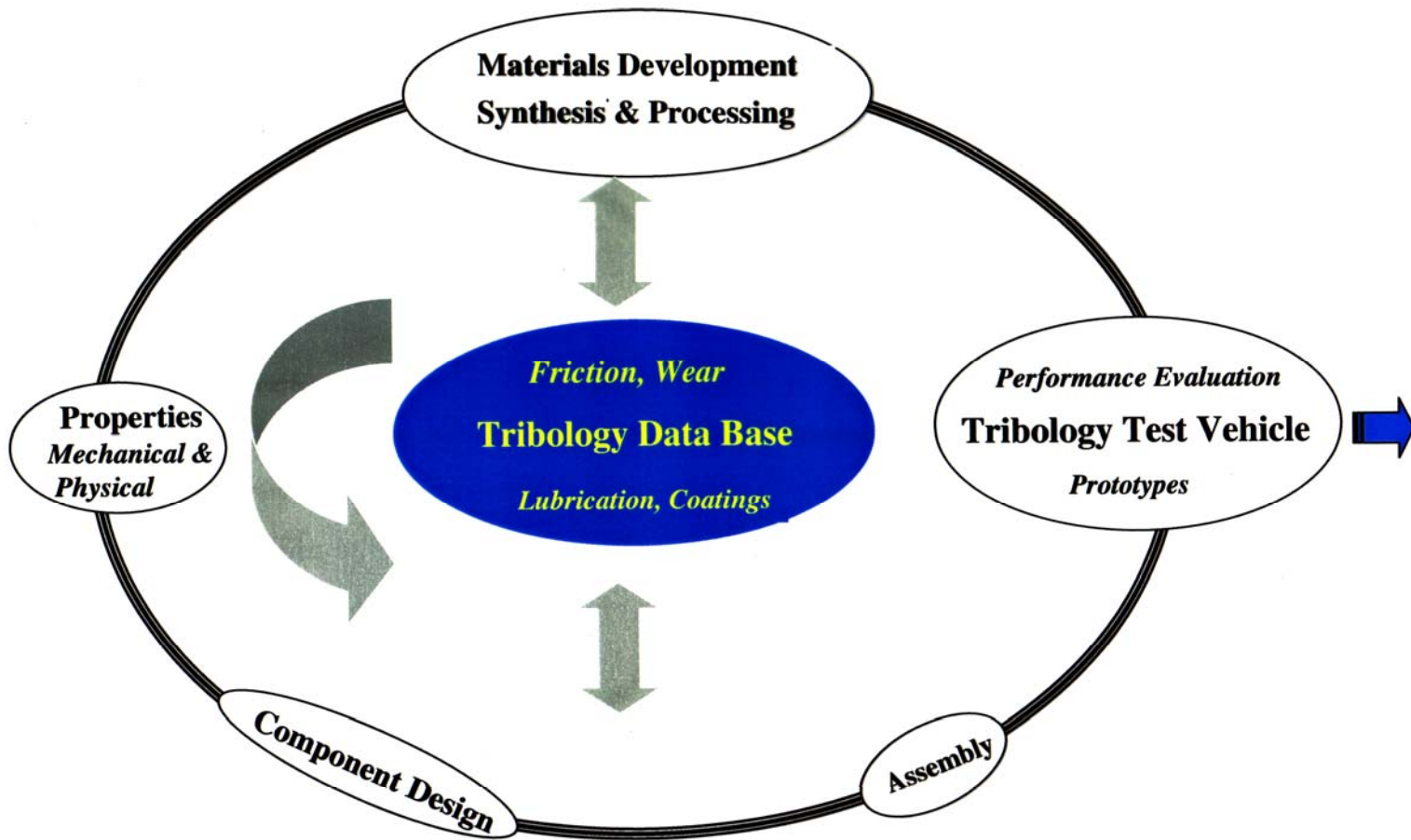
2. Gear bottom shadowed



3. Hub interior aspect ratio ~100



Concluding Thoughts: Systems Approach





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